

EPIC Meeting on Advanced Microoptics, 11-12 May 2022, Karlsruhe @ Nanoscribe

Examples of Flat Optics Designs

Frank Wyrowski

- University of Jena, Germany
- LightTrans International GmbH
- Wyrowski Photonics GmbH
- Beijing Luoxun Technology Co., Ltd.

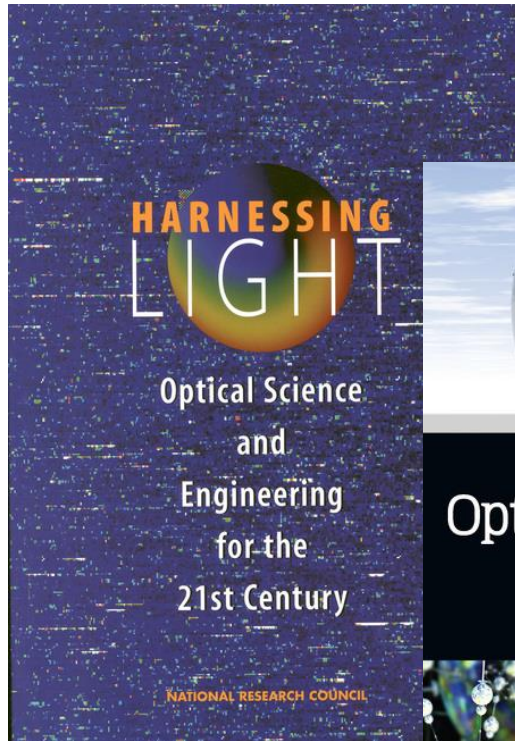
EPIC Meeting on Advanced Microoptics, 11-12 May 2022, Karlsruhe @ Nanoscribe

Physical Optics vs. Ray Optics and Conclusions for Flat Optics

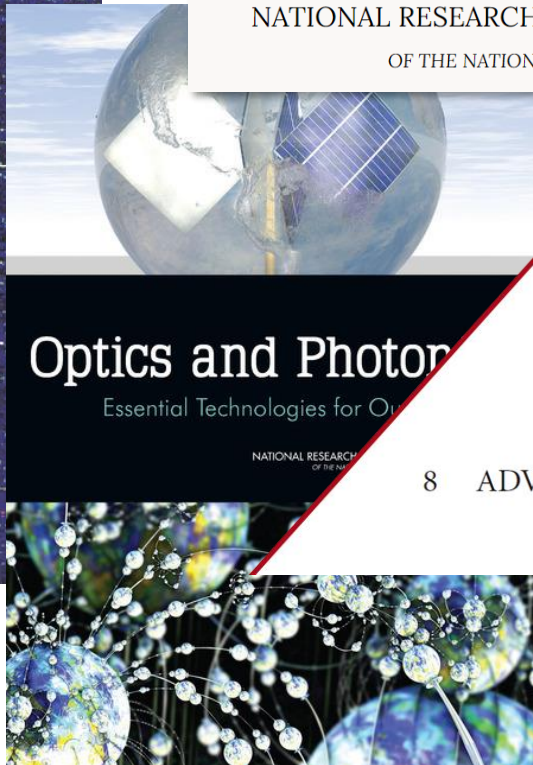
Frank Wyrowski

- University of Jena, Germany
- LightTrans International GmbH
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- Beijing Luoxun Technology Co., Ltd.

Optics and Photonics: Enabling Technology



1998



2013

Committee on Harnessing Light: Capitalizing on Optical Science Trends and Challenges for Future Research

National Materials and Manufacturing Board

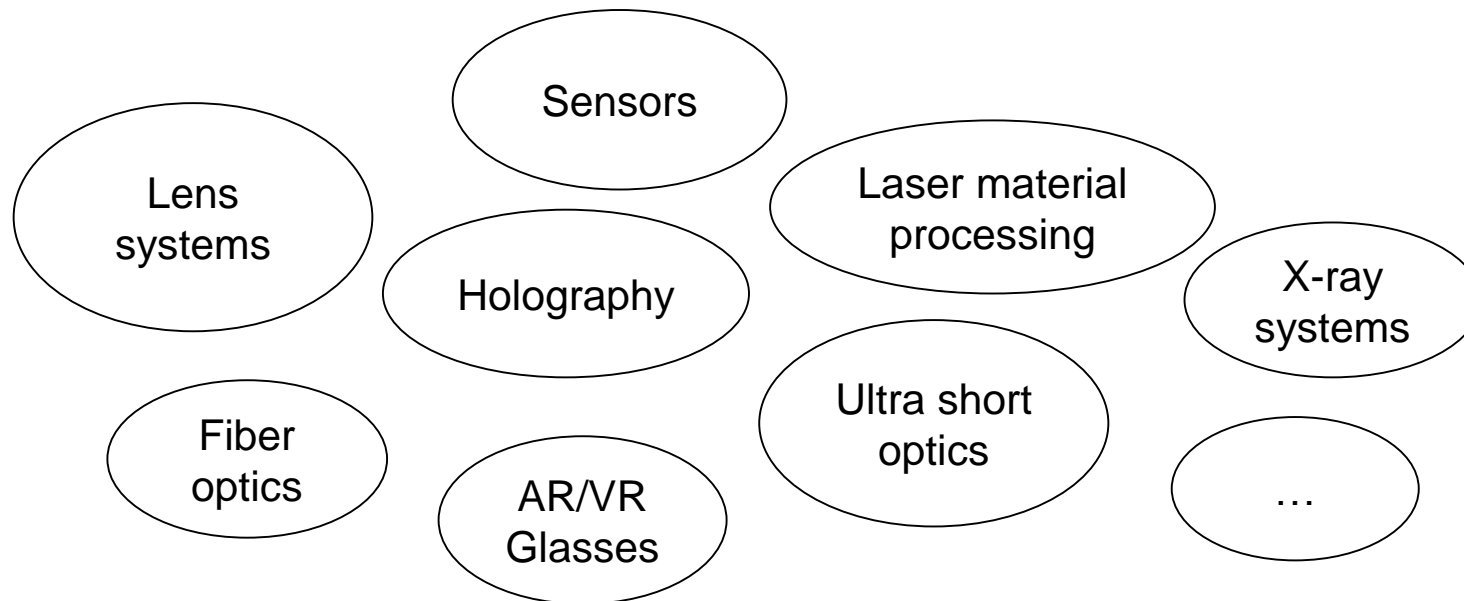
Division on Engineering and Physical Sciences

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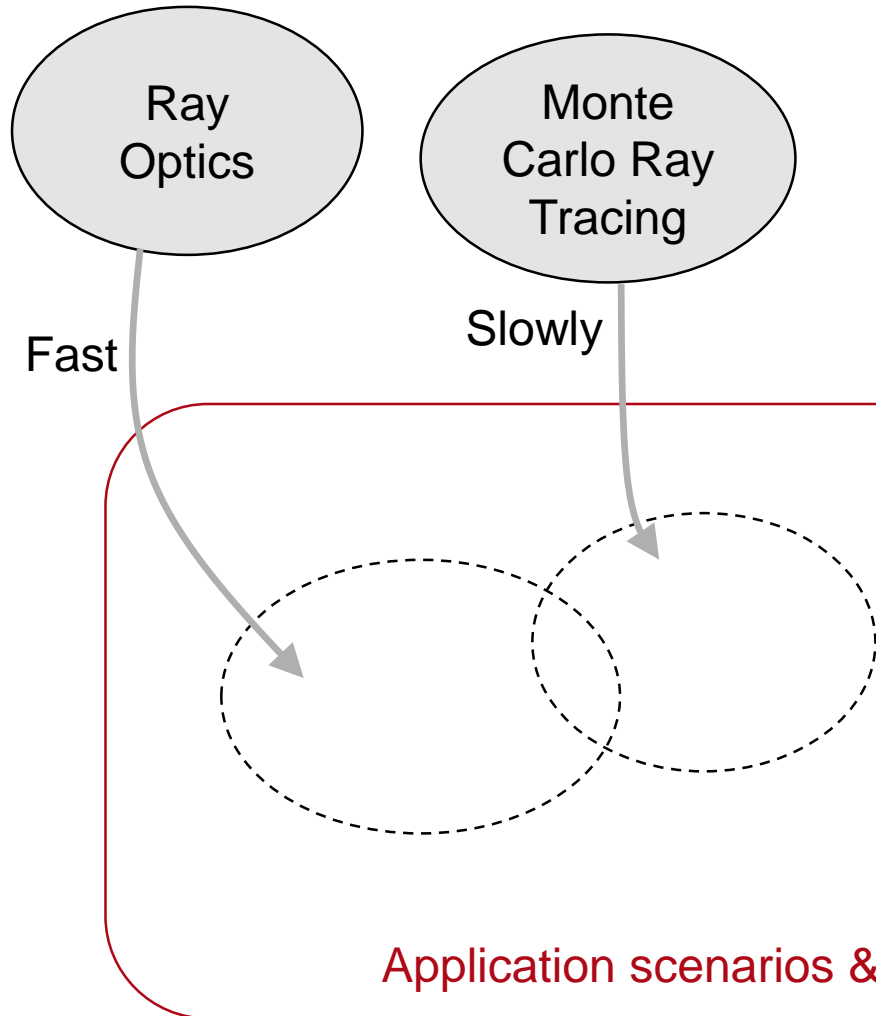
Enabling Technology: Huge Variety of Application Scenarios



Enabling Technology: Huge Variety of Application Scenarios

Application scenarios & modeling/design tasks

Modeling Techniques



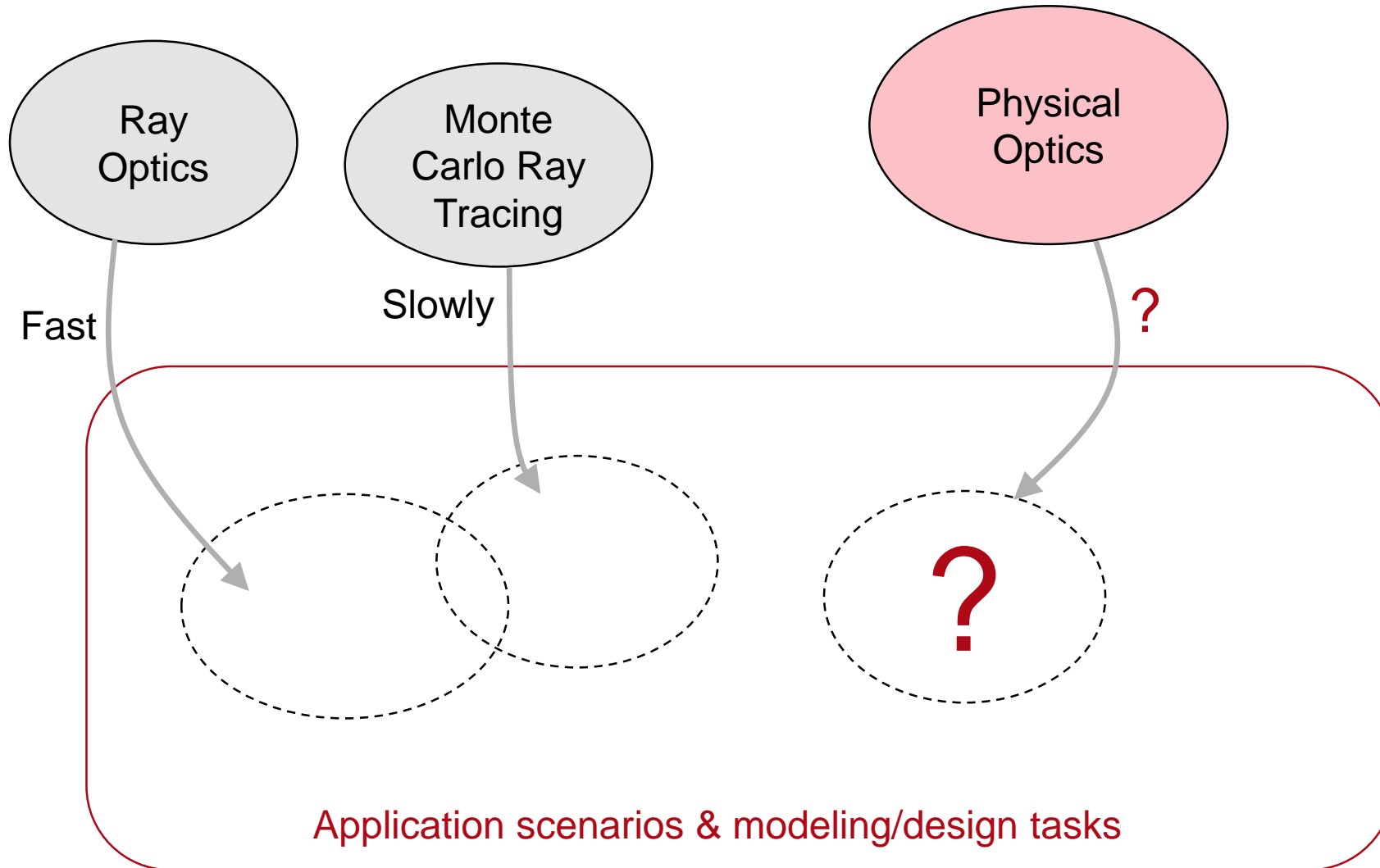
- **Ray tracing:**

- Pointwise operation
- Numerical complexity $O(N)$ (N number of rays)
- Small N

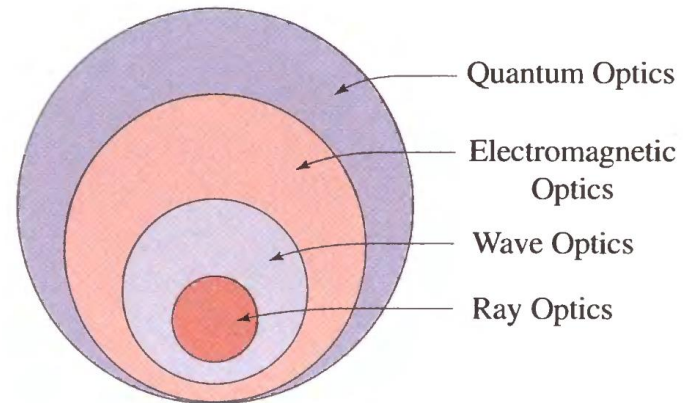
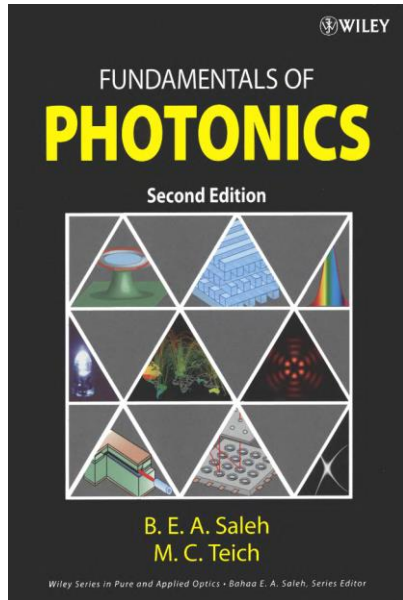
- **Monte Carlo ray tracing:**

- Integral operation, statistical evaluation
- Numerical complexity $O(N^2)$ (N number of ray bundles)
- Large N

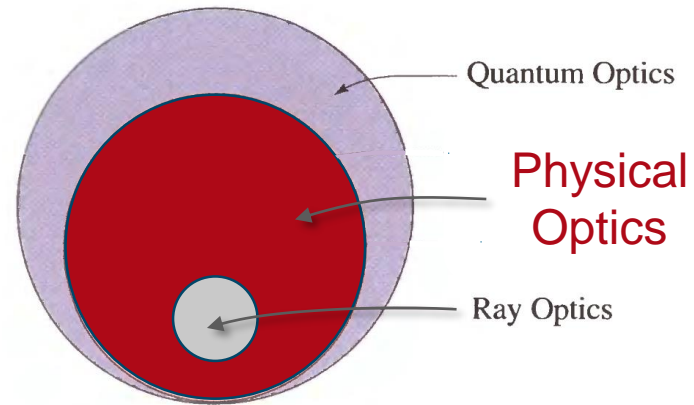
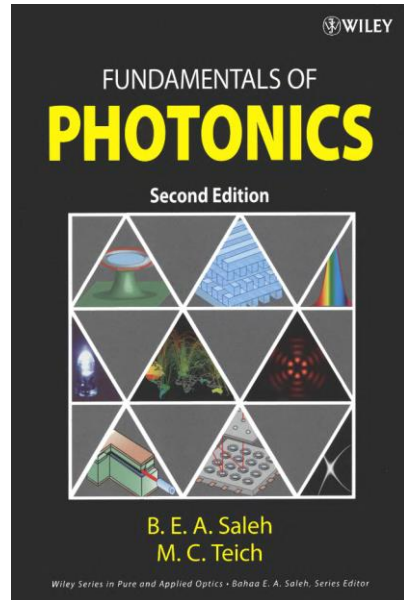
Modeling Techniques



Physical Optics Includes Ray Optics



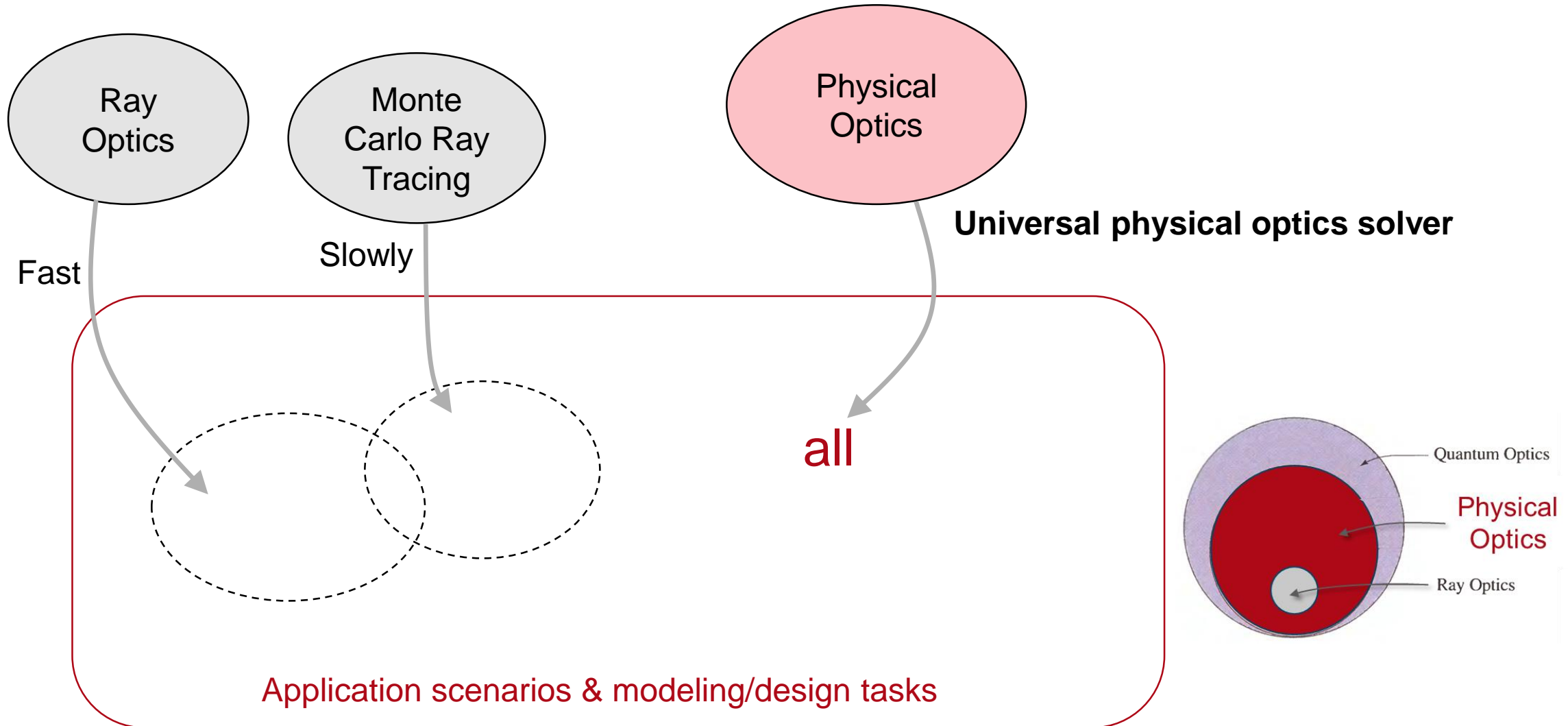
Physical Optics Includes Ray Optics



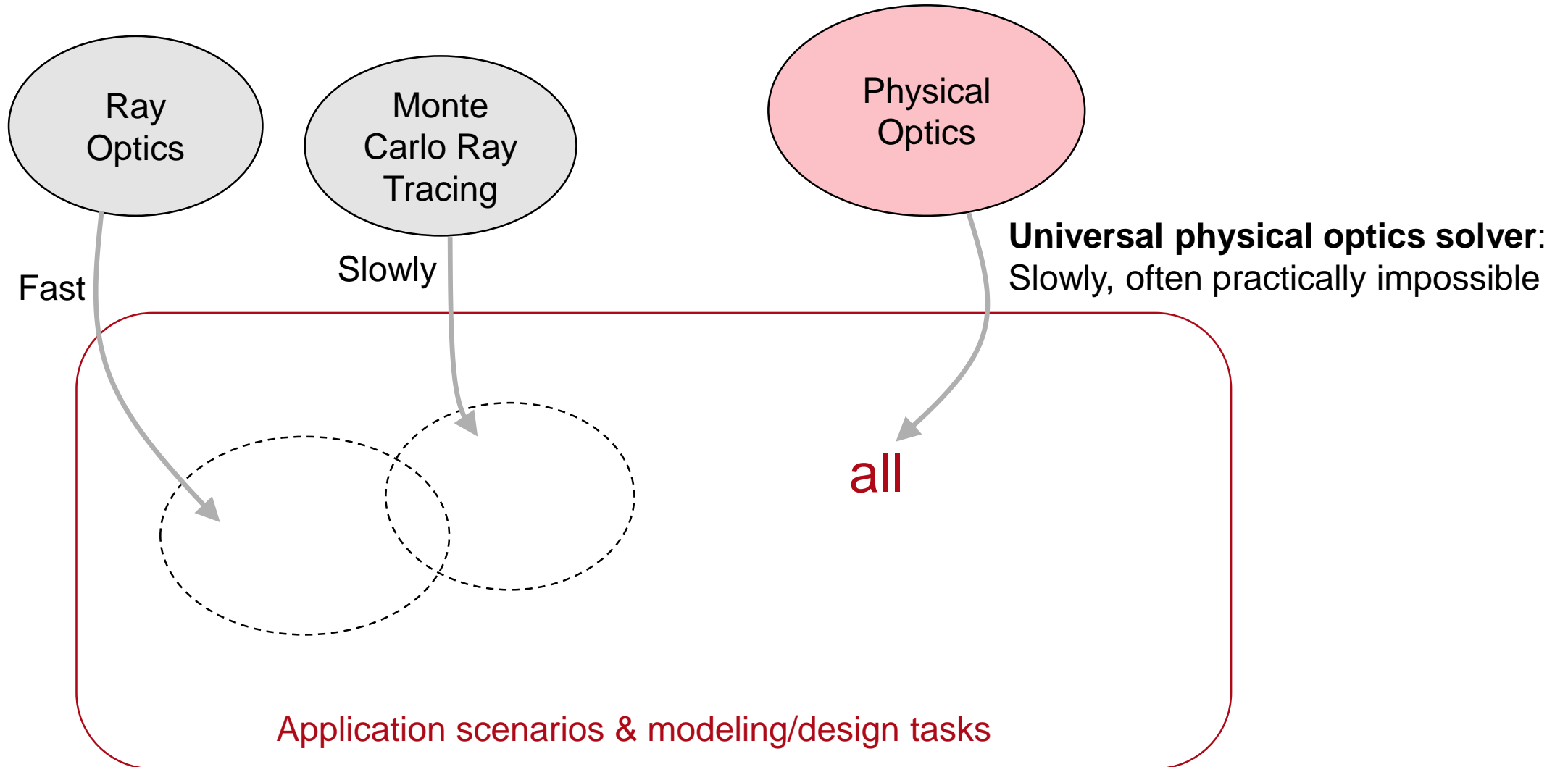
- **Universal physical optics solver:**

- Integral operation
- Numerical complexity $O(N^2)$ and higher (N number of field sampling values)
- Large to huge N
(proportional to modeling volume $(\Delta s/\lambda)^3$)

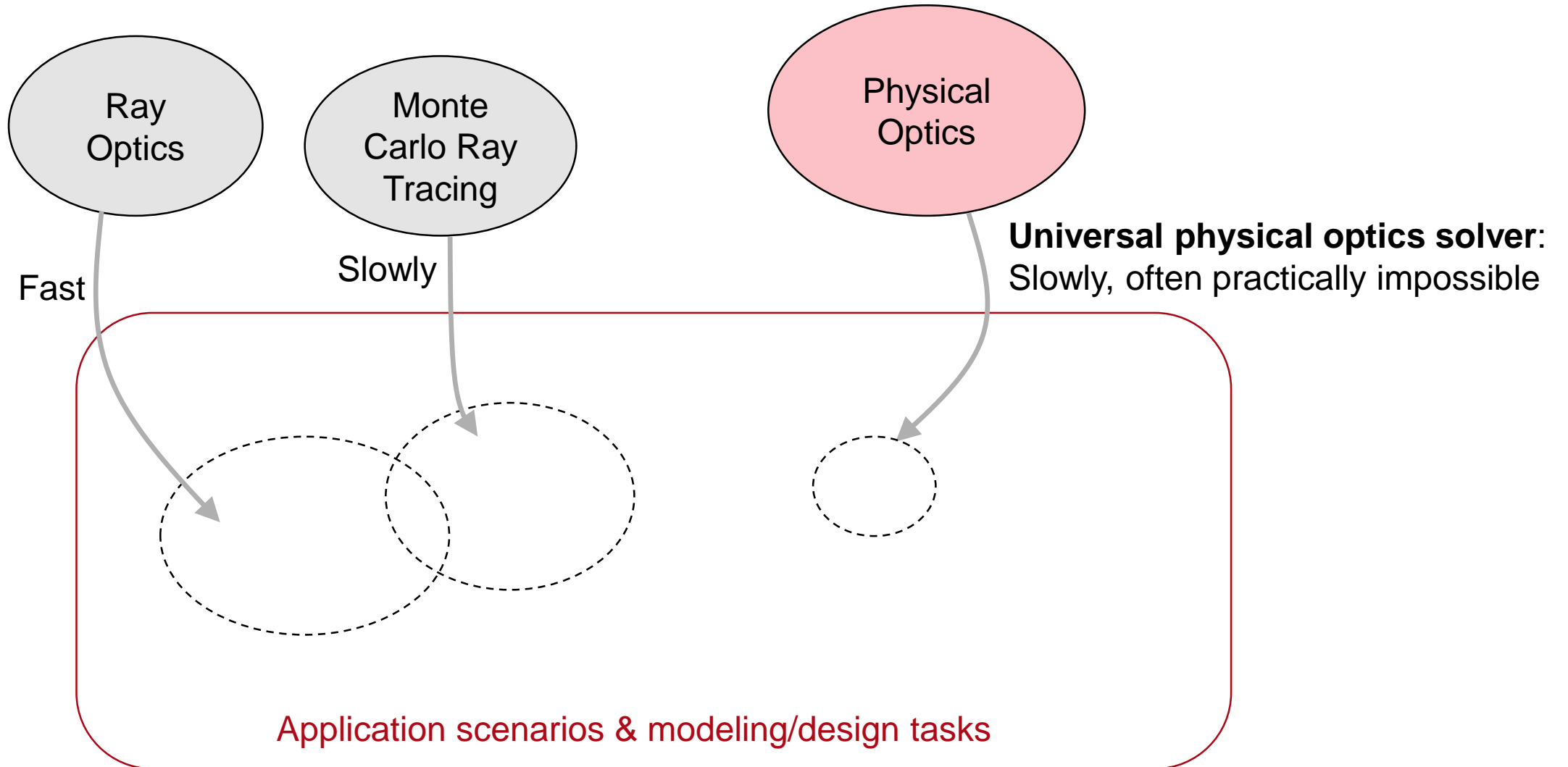
Modeling Techniques



Modeling Techniques



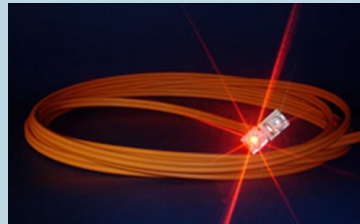
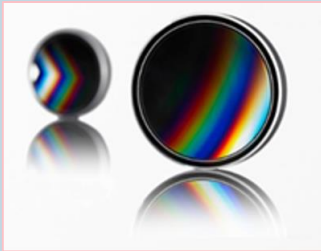
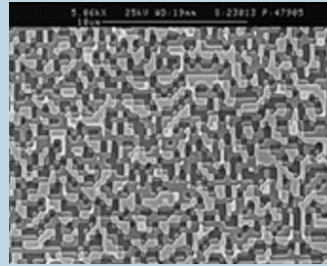
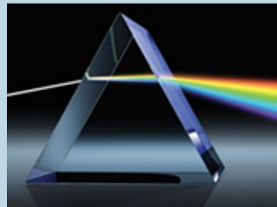
Modeling Techniques



Physical Optics Modeling by Universal Solver

Universal Solver

$O(N^2), O(N^3)$



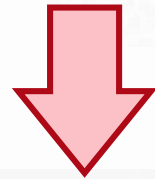
Components in optical system

- **Universal physical optics solver:**

- Integral operation
- Numerical complexity $O(N^2)$ and higher (N number of field sampling values)
- Large to huge N (proportional to modeling volume $(\Delta_s/\lambda)^3$)

Physical Optics Modeling by Universal Solver

One-size-fits-all
physical-optics solver



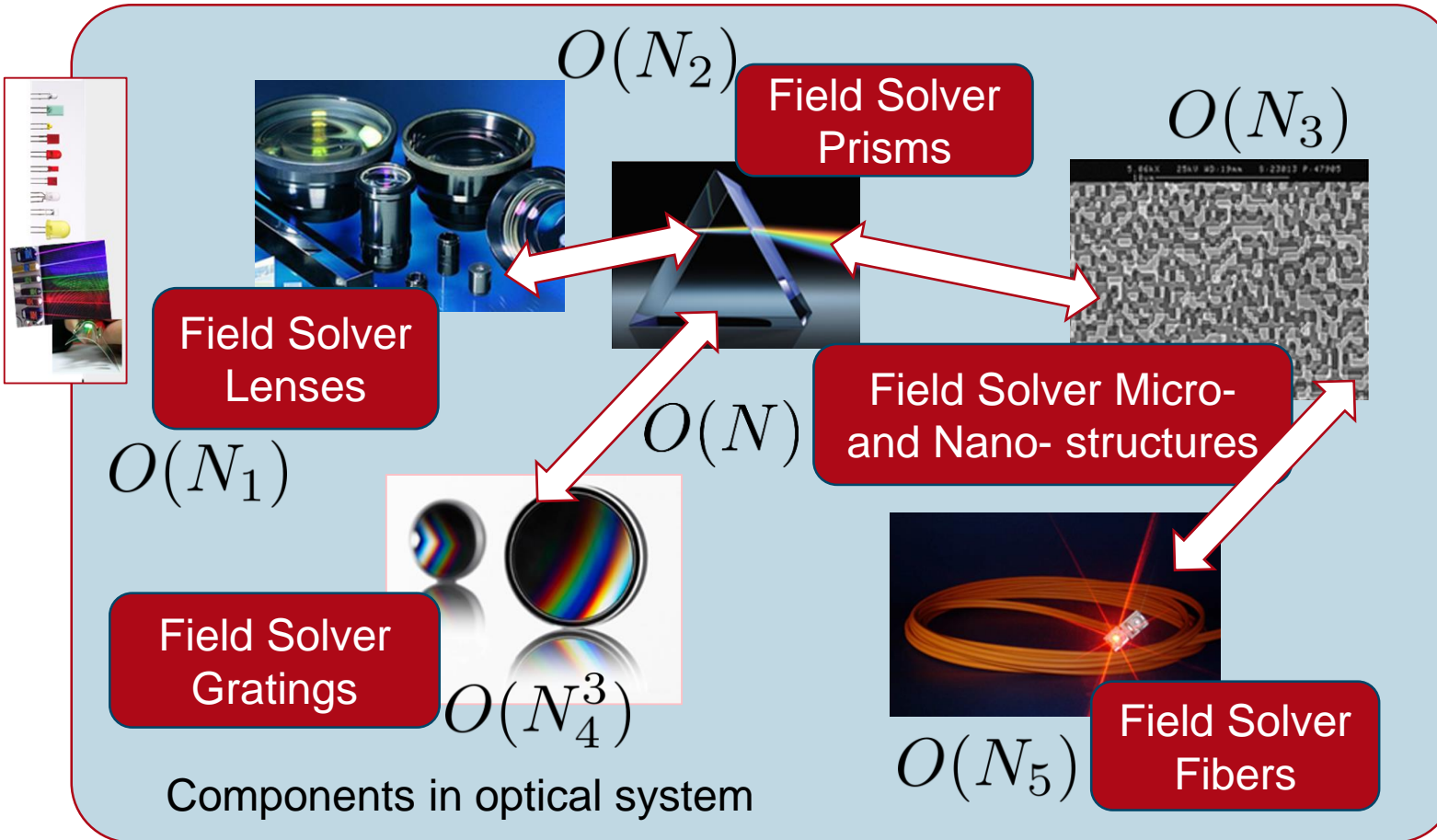
Various specialized
physical-optics solvers

Universal physical optics solver:

- Integral operation
- Numerical complexity $O(N^2)$ and higher (N number of field sampling values)
- Large to huge N (proportional to modeling volume $(\Delta_s/\lambda)^3$)

Components in optical system

Physical Optics Modeling by Connecting Solvers

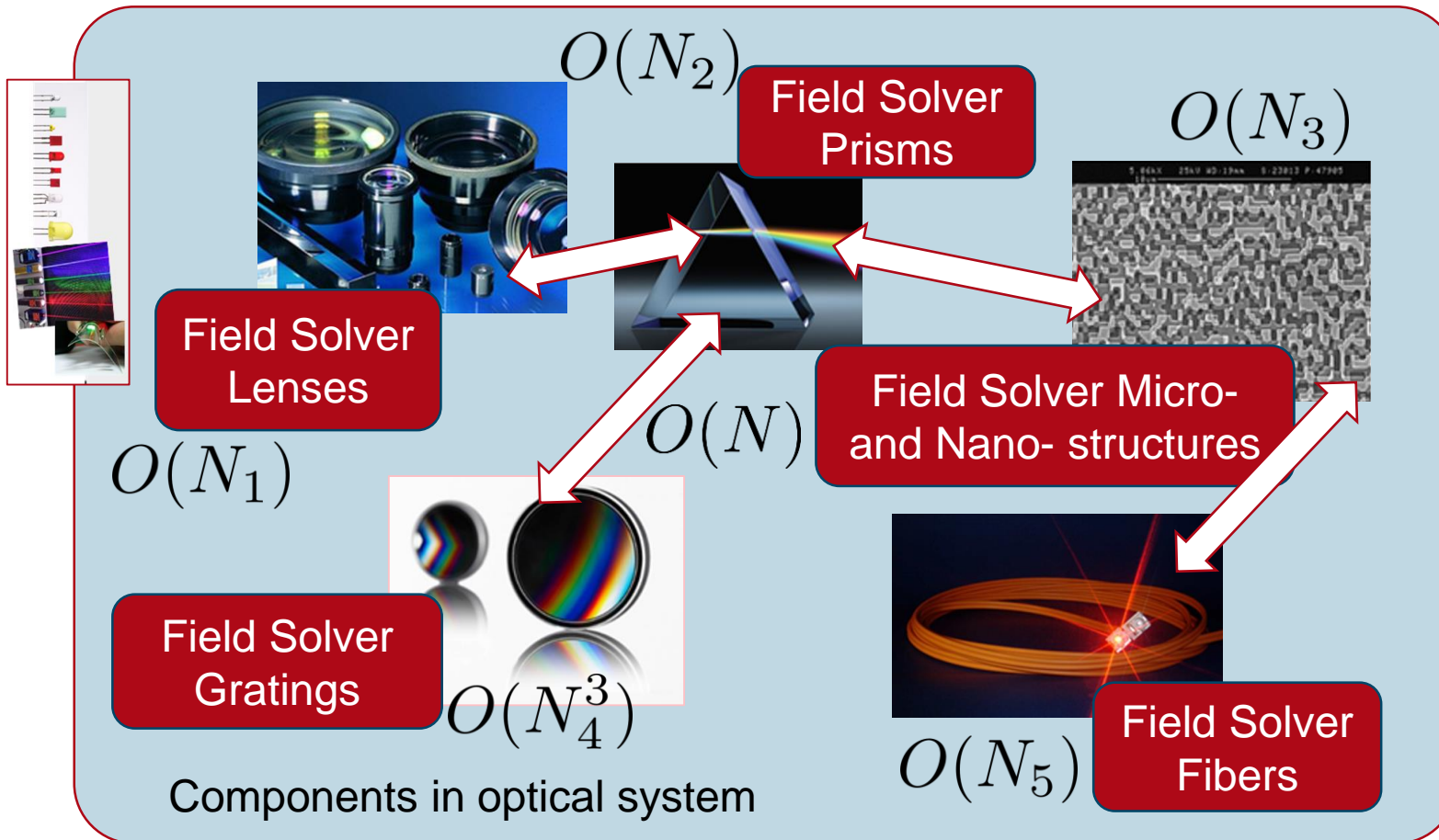


- **Connecting specialized physical optics solvers:**

- Pointwise and integral operations for different components (index j)
- Numerical complexity of different solvers varies from $O(N_j)$ to $O(N_j^2)$ and higher
- Minimized N_j : small to large

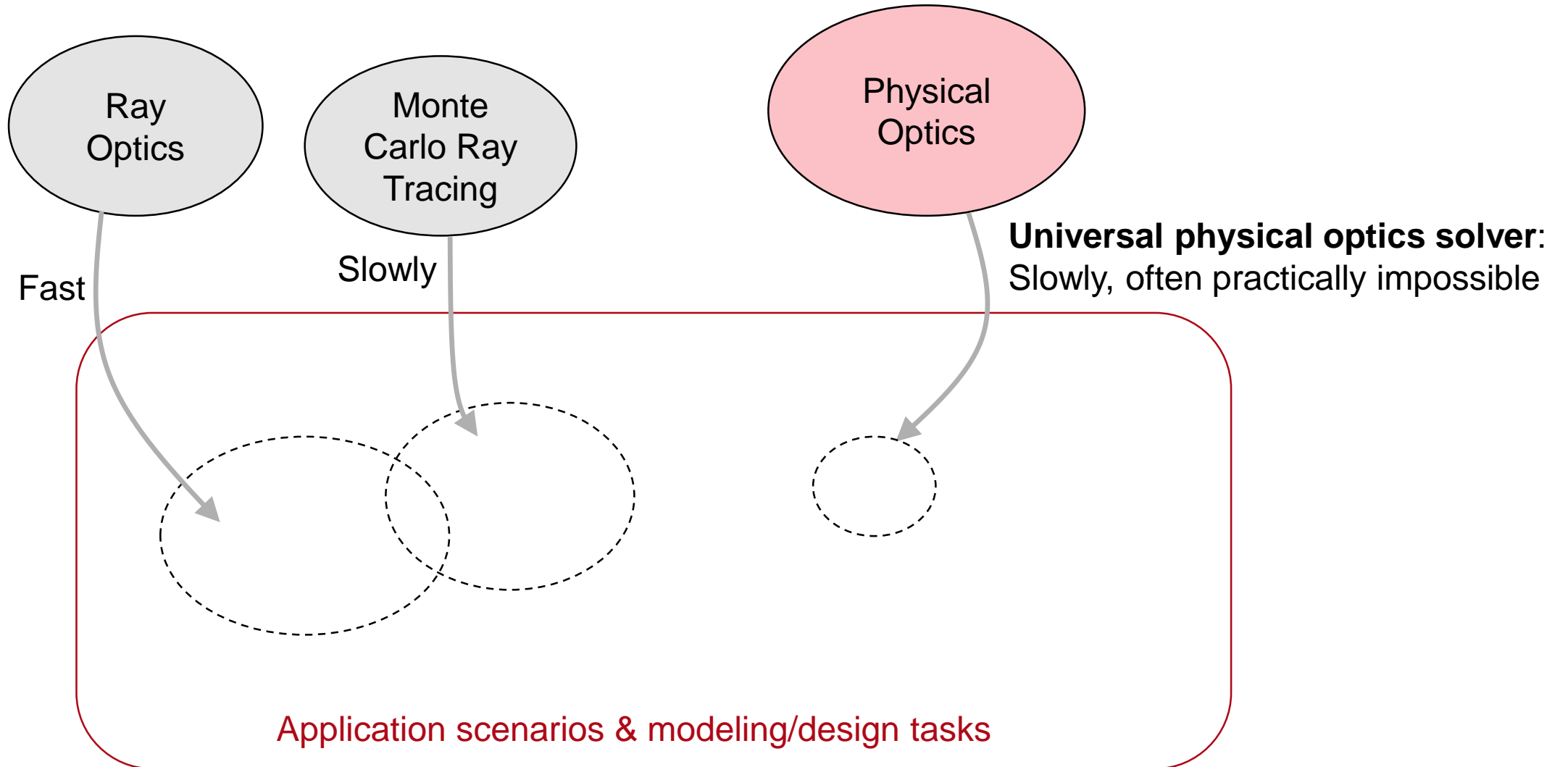
- Dominant integral operation is Fourier transform; FFT complexity $O(N \log N)$

Fast Physical Optics

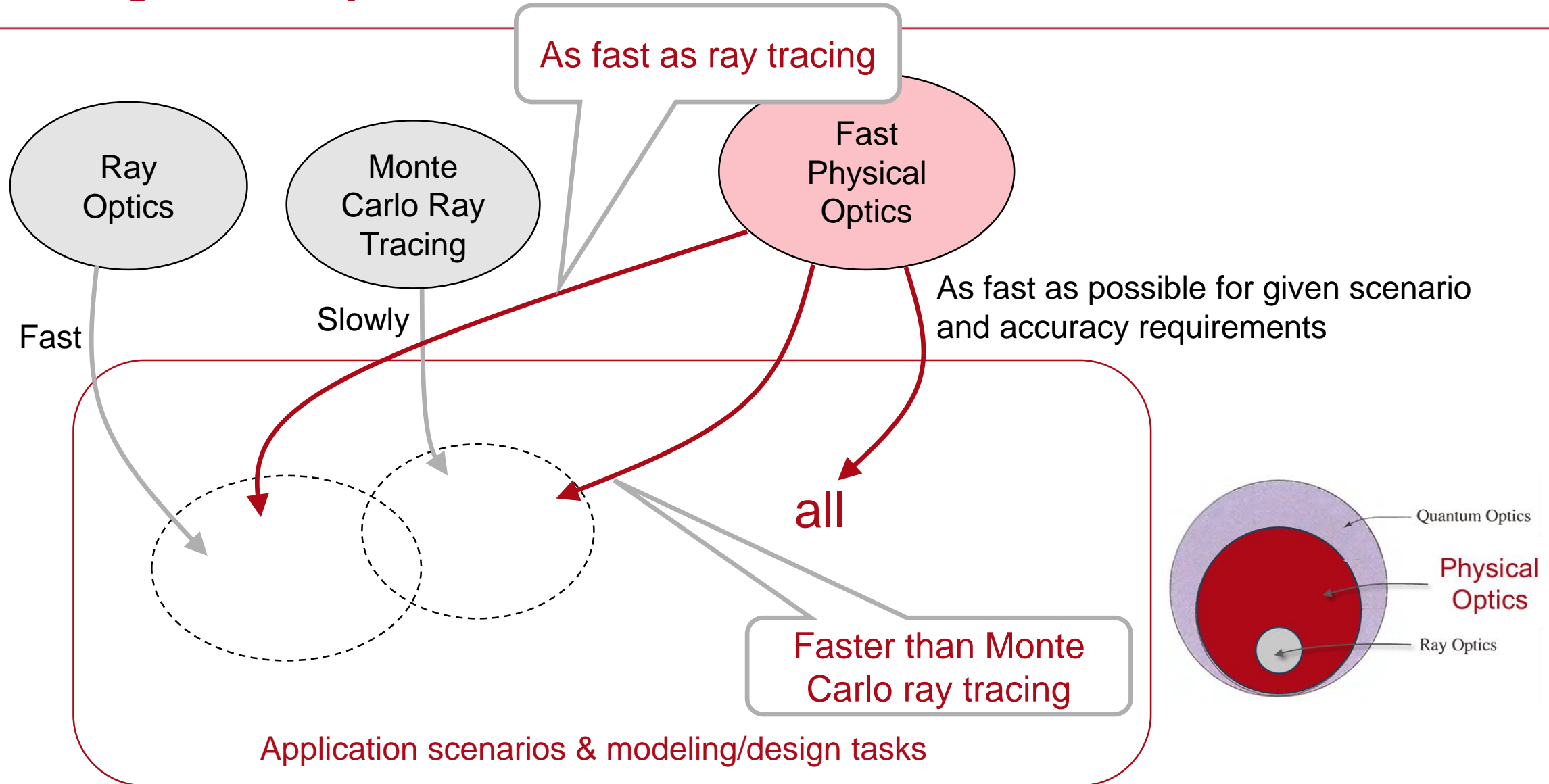


- Apply tailored solvers and sampling N per component.
- Use solvers with numerical complexity $O(N)$ wherever possible.

Modeling Techniques

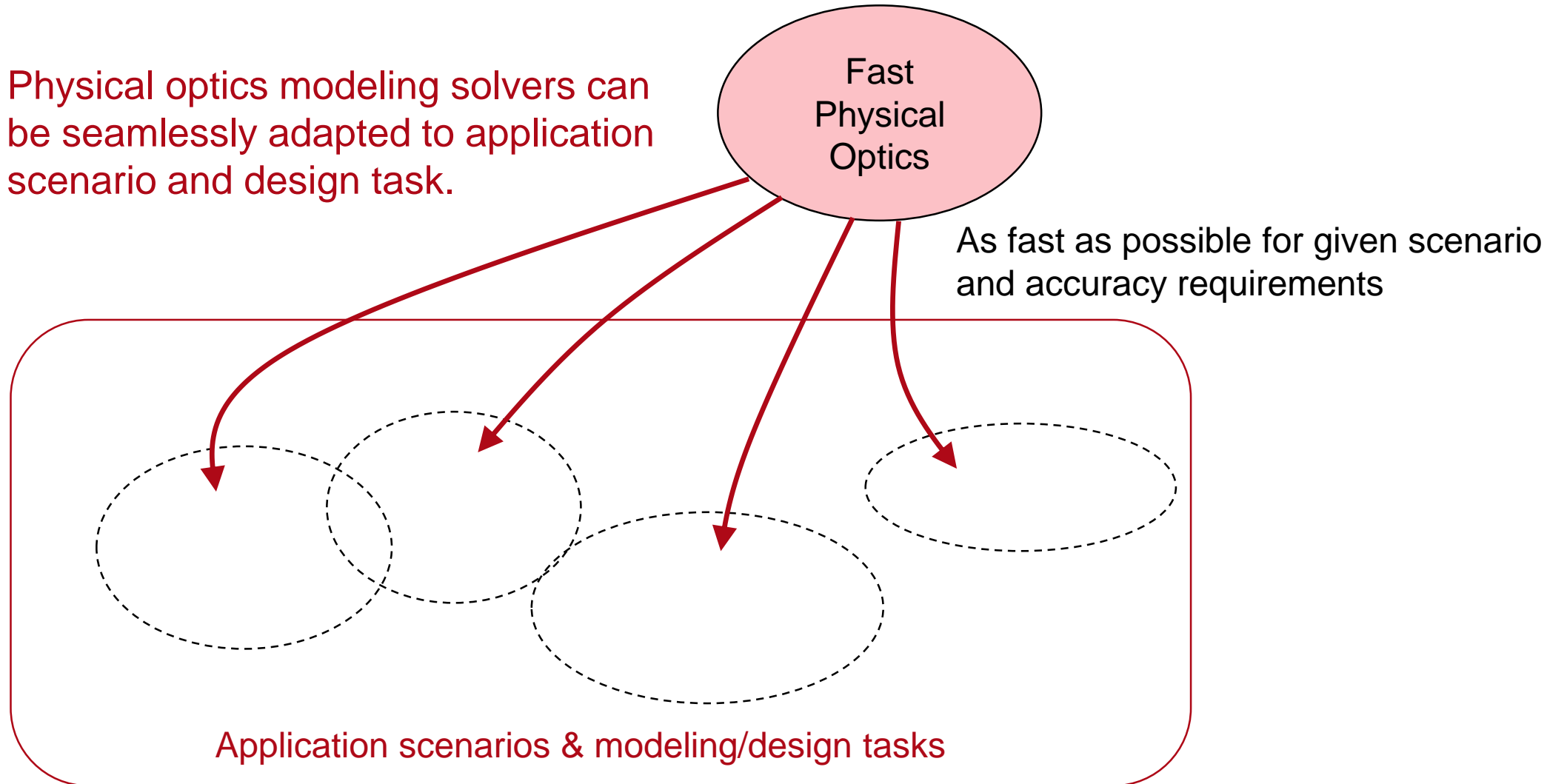


Modeling Techniques



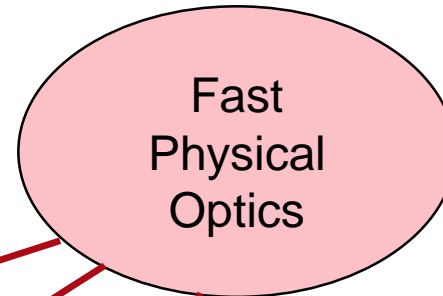
Fast Physical Optics Modeling and Design

Physical optics modeling solvers can be seamlessly adapted to application scenario and design task.

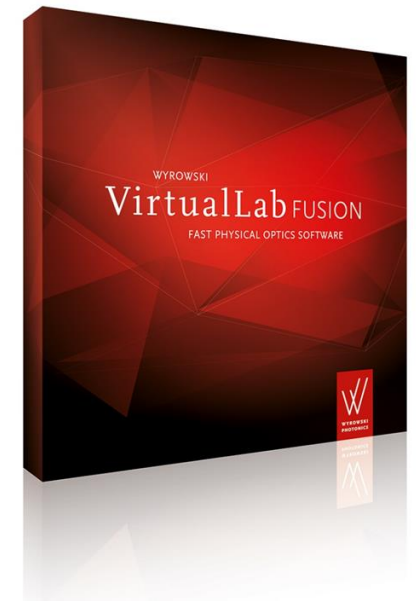
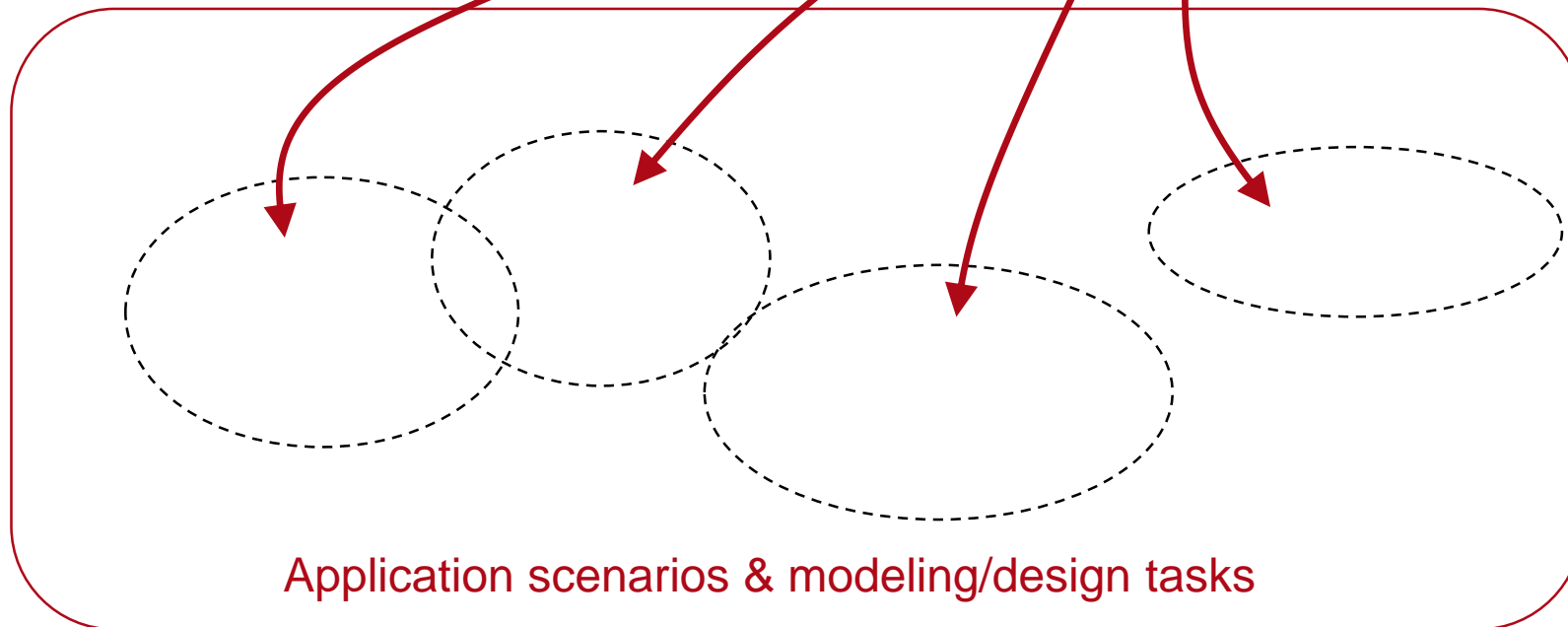


Fast Physical Optics Modeling and Design

Physical optics modeling solvers can be seamlessly adapted to application scenario and design task.



As fast as possible for given scenario and accuracy requirements



Fast Physical Optics Modeling and Design

Physical optics modeling solvers can be seamlessly adapted to application scenario and design task.

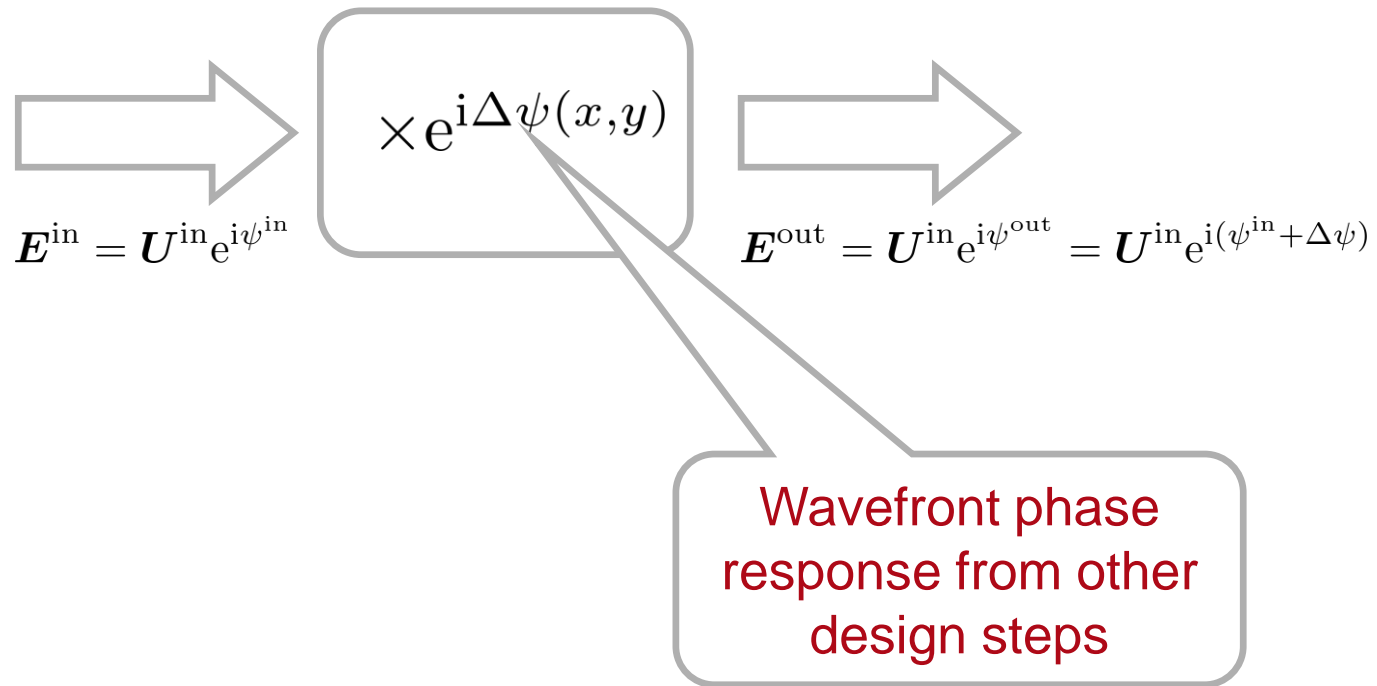
Fast
Physical
Optics

As fast as possible for given scenario
and accuracy requirements

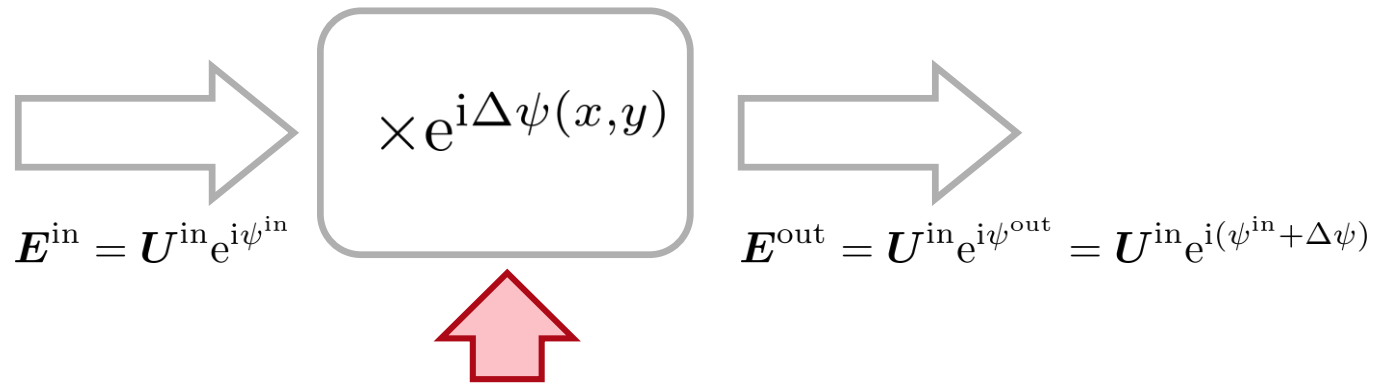
$\geq O(N)$
Flat optics

Application scenarios & modeling/design tasks

Wavefront Phase Manipulation

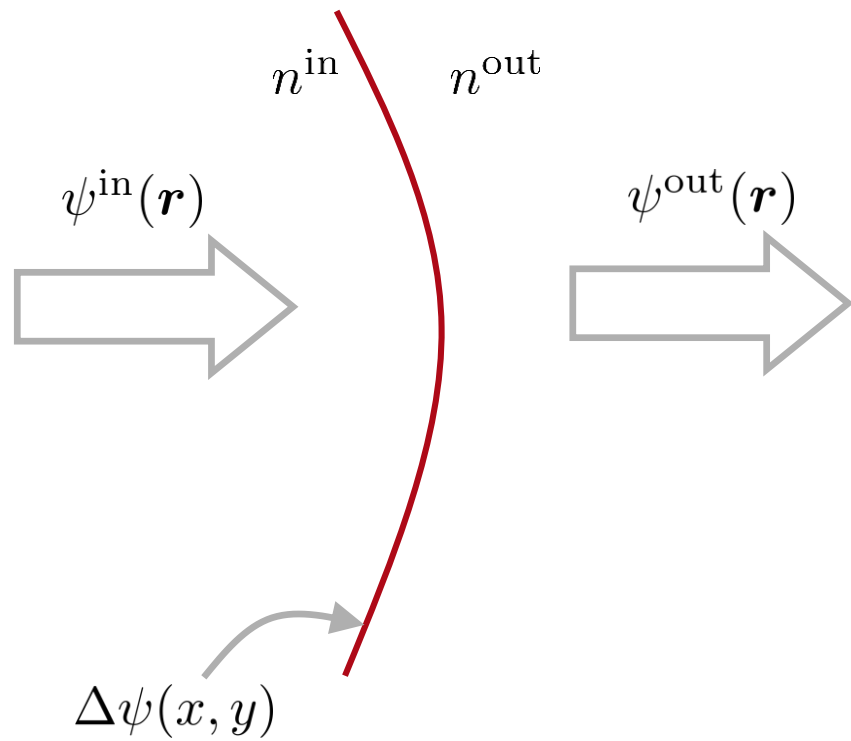


Wavefront Phase Manipulation

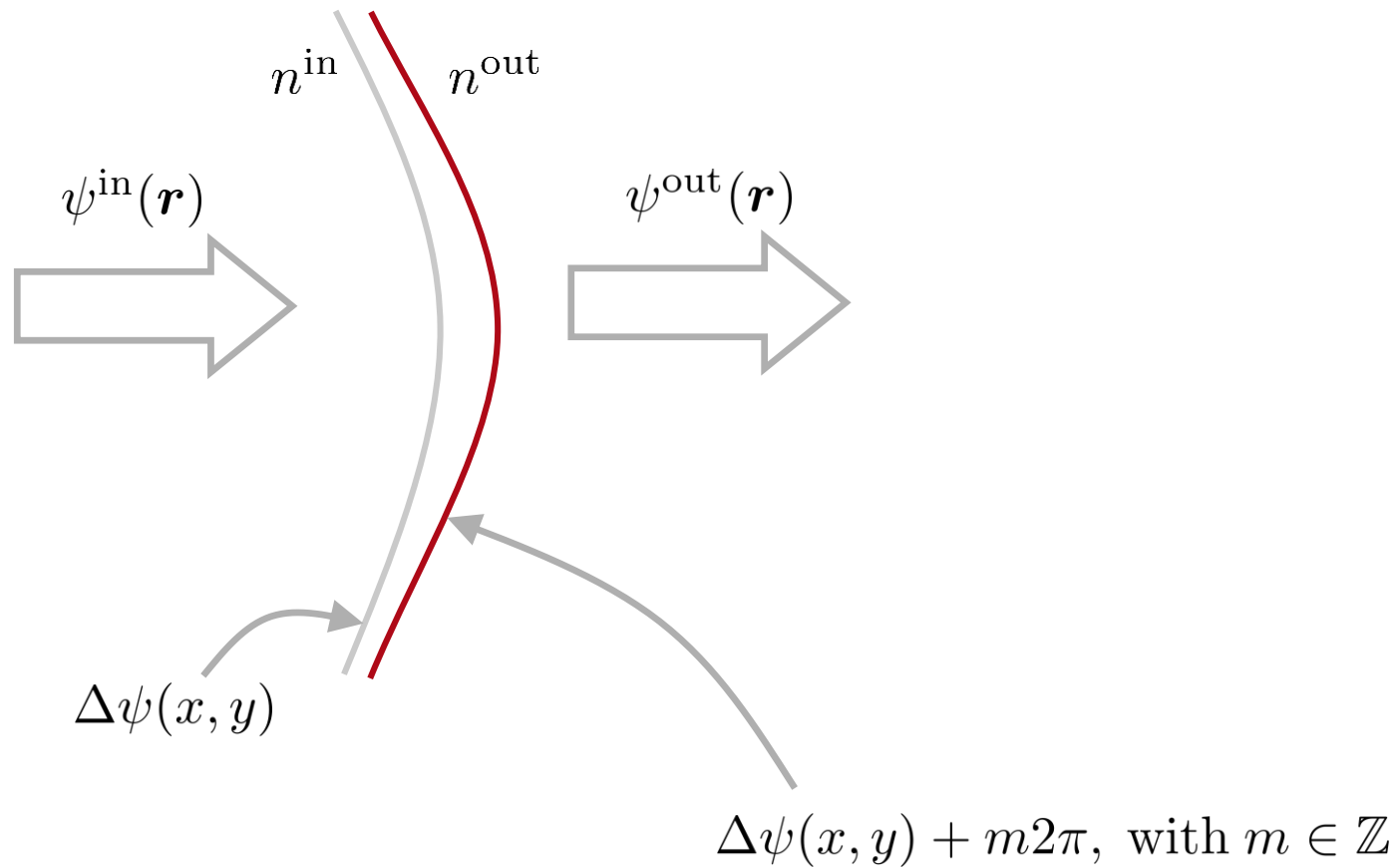


Which structures can be used
to realize wavefront phase
response in practice?

Smooth Surface Design



Multiple Surface Designs

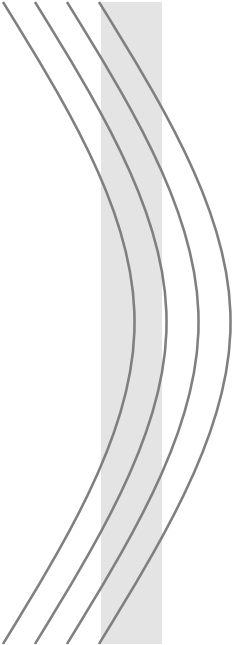


Multiple Surface Designs



Set of surface designs with:
 $\Delta\psi(x, y) + m2\pi$, with $m \in \mathbb{Z}$

Regional Usage of Multiple Surfaces: Flatten of Surface



Regional Usage of Multiple Surfaces: Flatten of Surface



All surfaces can be used for the wavefront manipulation. So, we may use them in different regions as well.

Regional Usage of Multiple Surfaces: Flatten of Surface



Regional Usage of Multiple Surfaces: Flatten of Surface

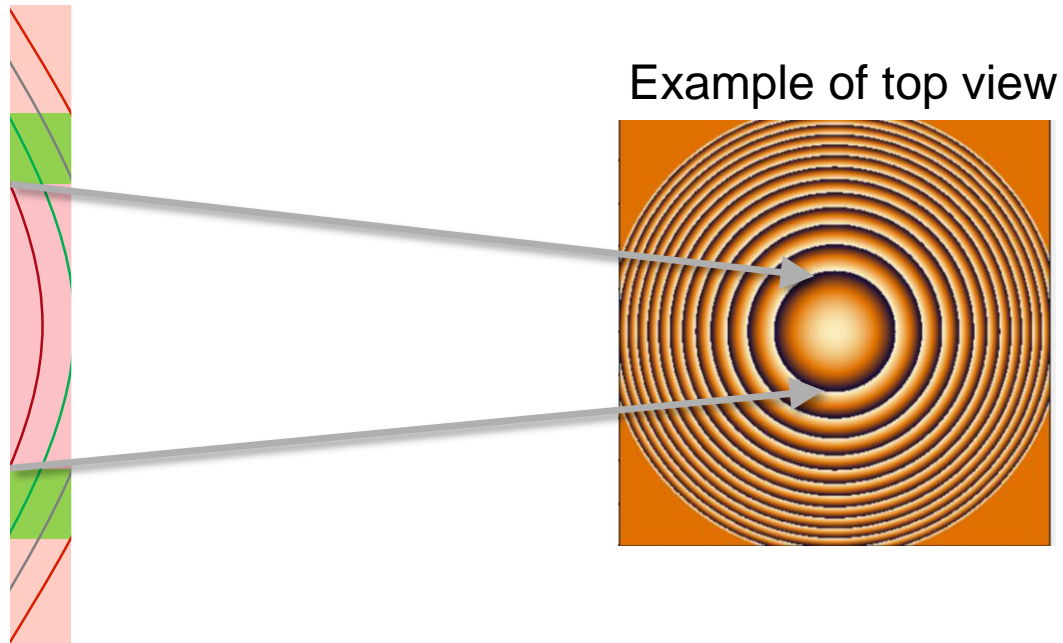


Regional Usage of Multiple Surfaces: Flatten of Surface



In the red region we use the red surface.

Regional Usage of Multiple Surfaces: Flatten of Surface

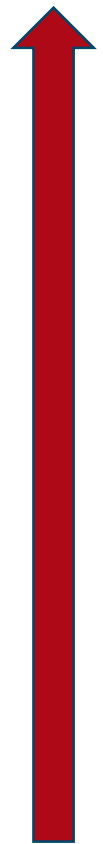


Example: Oculus Rift S VR Glasses (Meta)

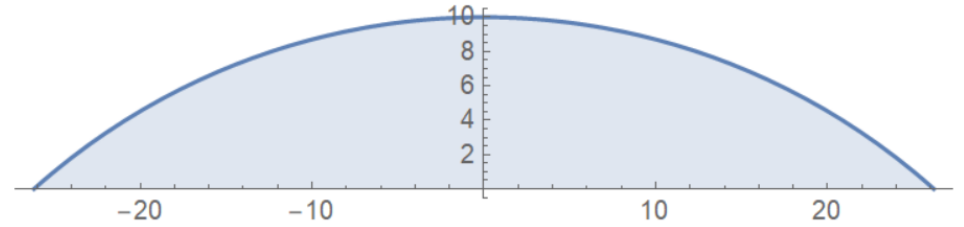


Segmented Surfaces

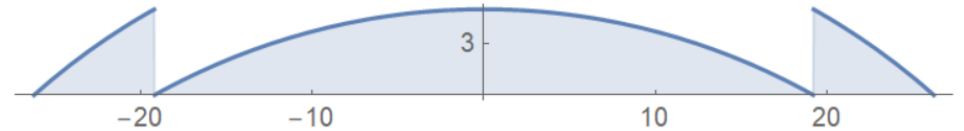
Schematic figure only!



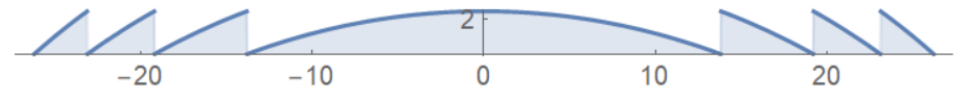
$\Delta m = 4$



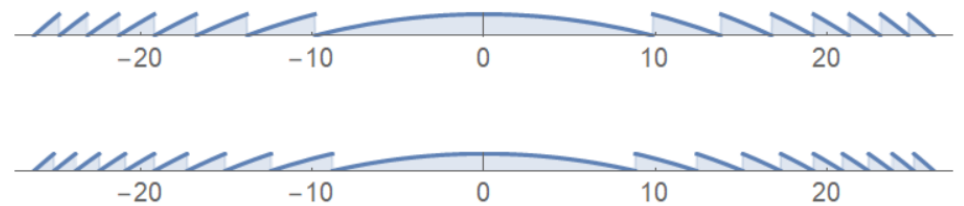
$\Delta m = 3$



$\Delta m = 2$



$\Delta m = 1$



Segmented Surfaces

Refractive lens
Freeform lens/surface
Aspherical lens

·
·
·

Segmented lens/surface
Fresnel lens

·
·
·

Diffractive lens, DOE
Holographic optical element (HOE)



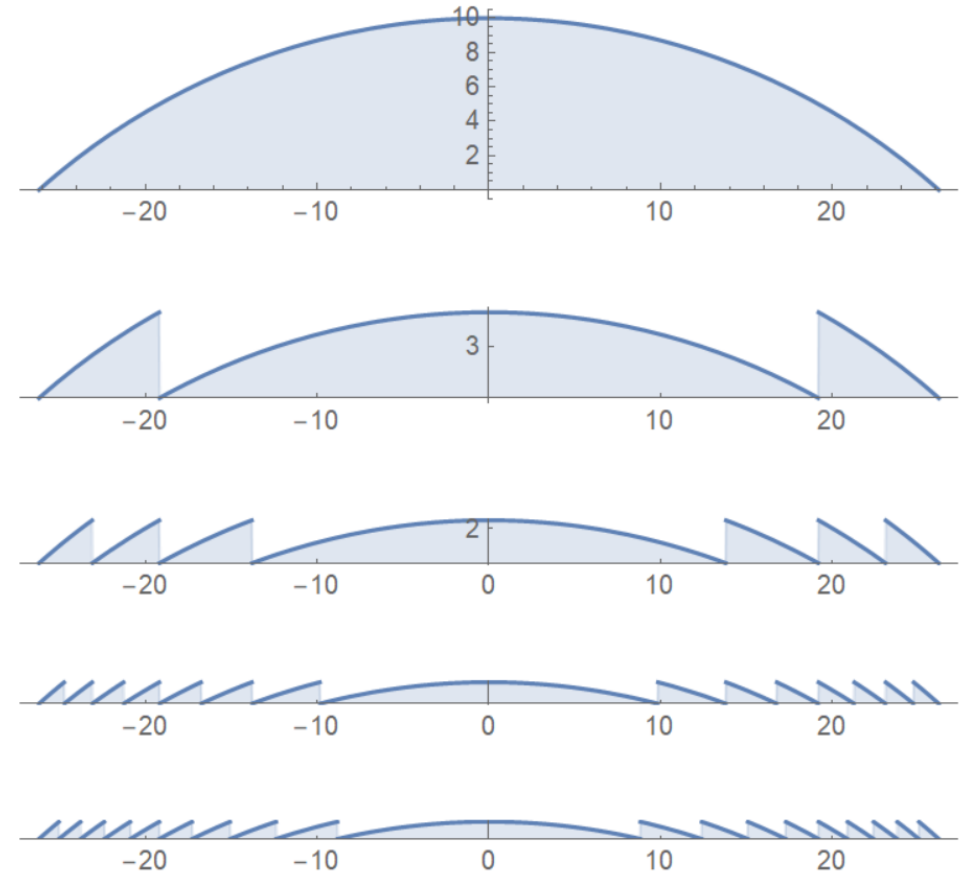
$$\Delta m = 4$$

$$\Delta m = 3$$

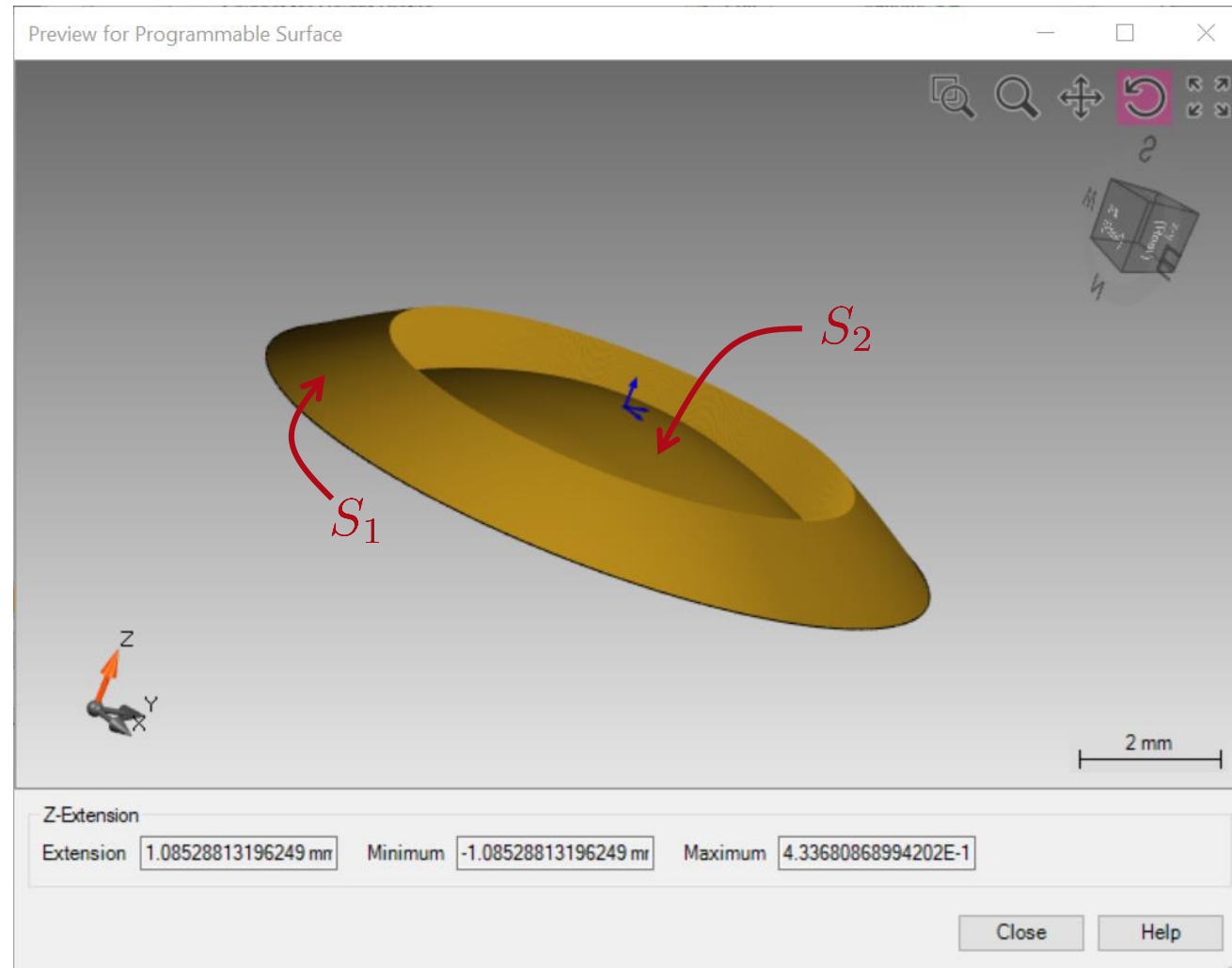
$$\Delta m = 2$$

$$\Delta m = 1$$

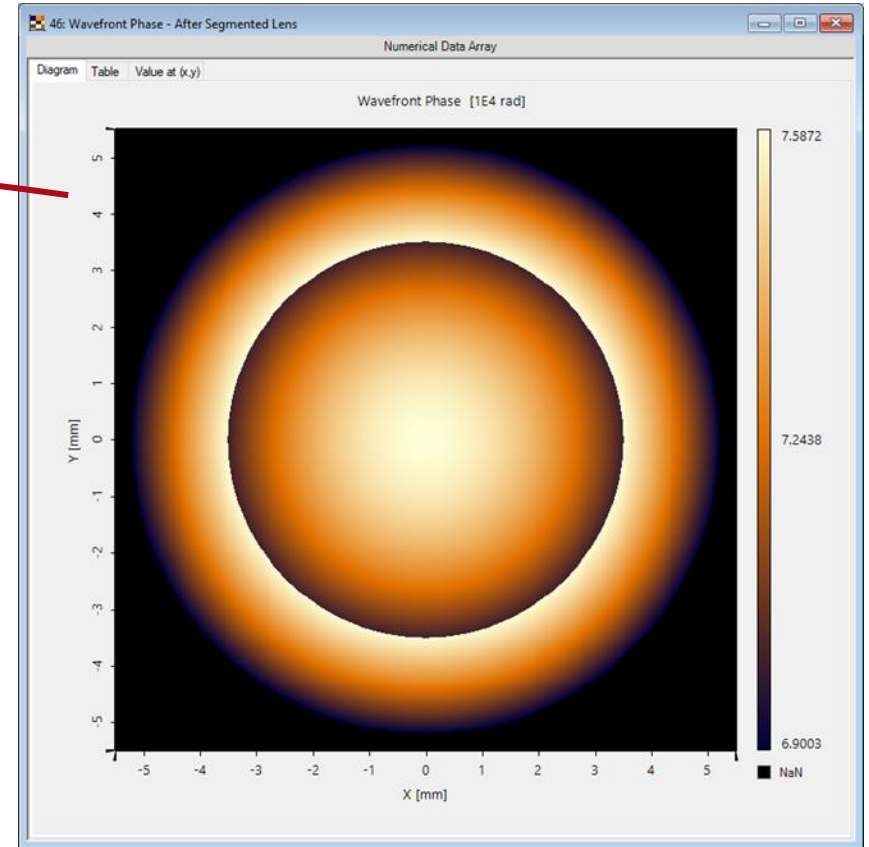
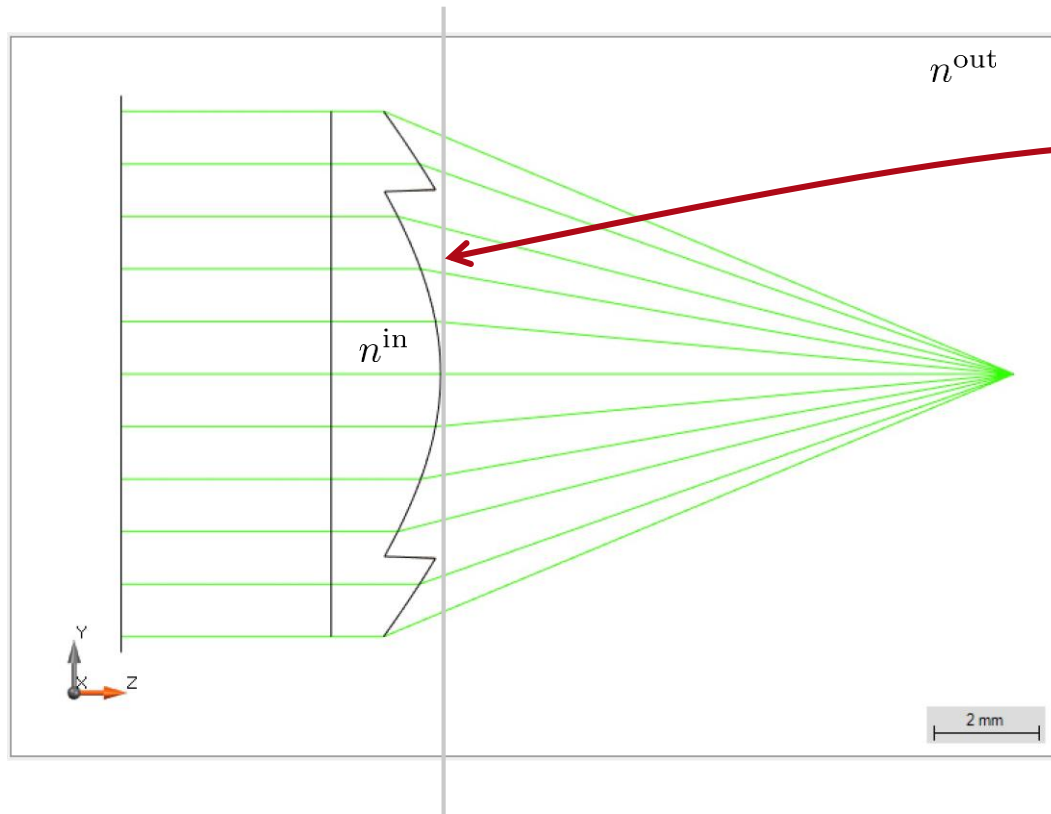
Schematic figure only!



Structural Design Segmented Lens: Focusing NA 0.4



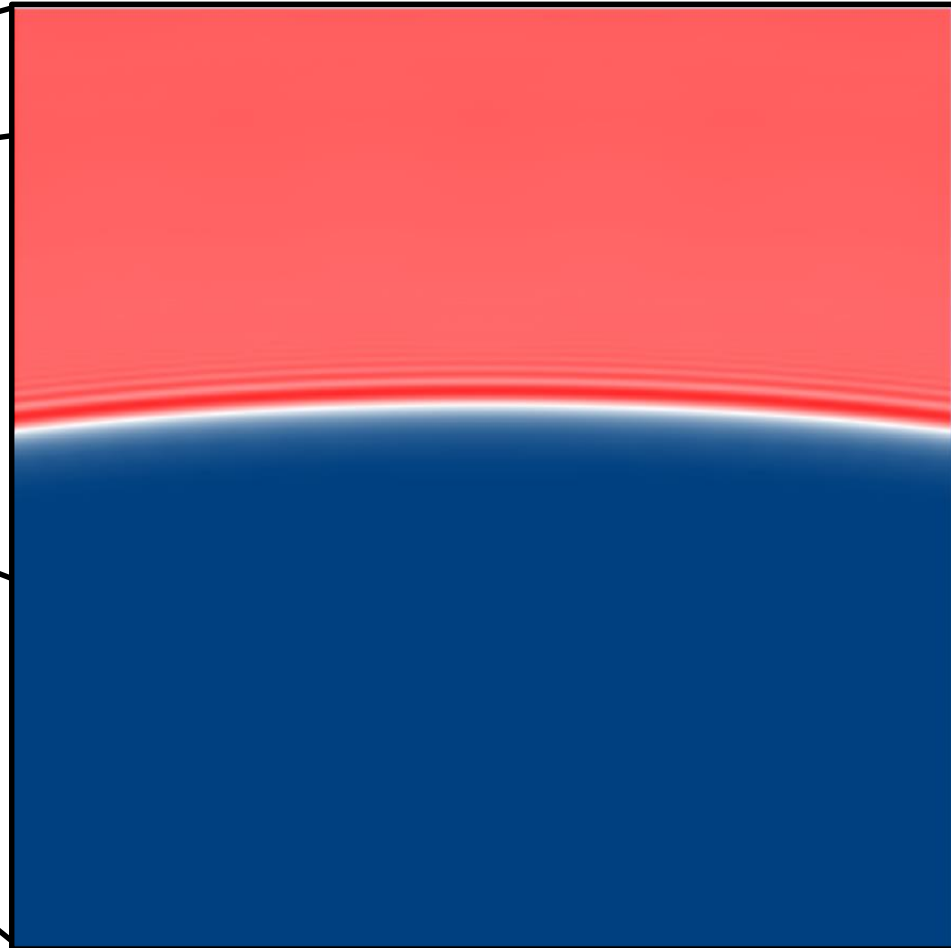
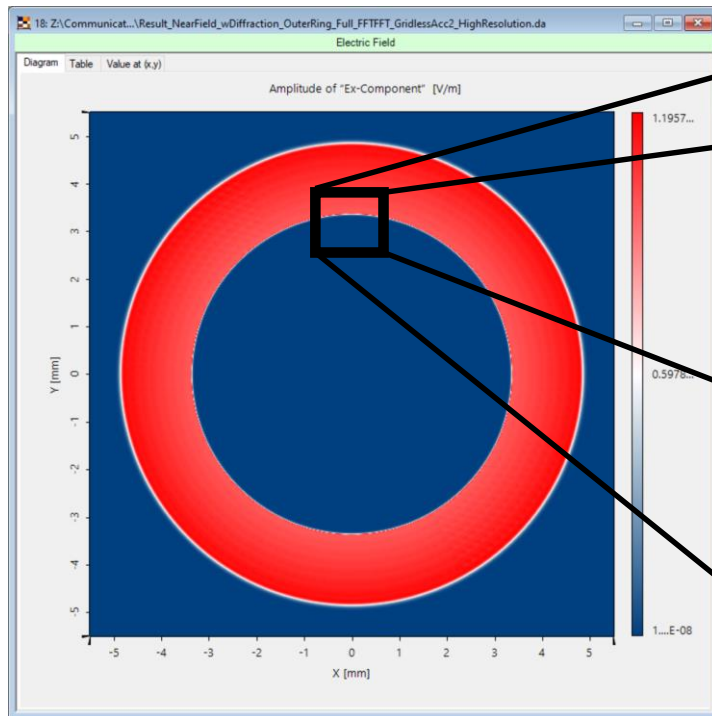
Focusing (NA = 0.4) Lens: Physical-Optics Modeling



Phase behind lens

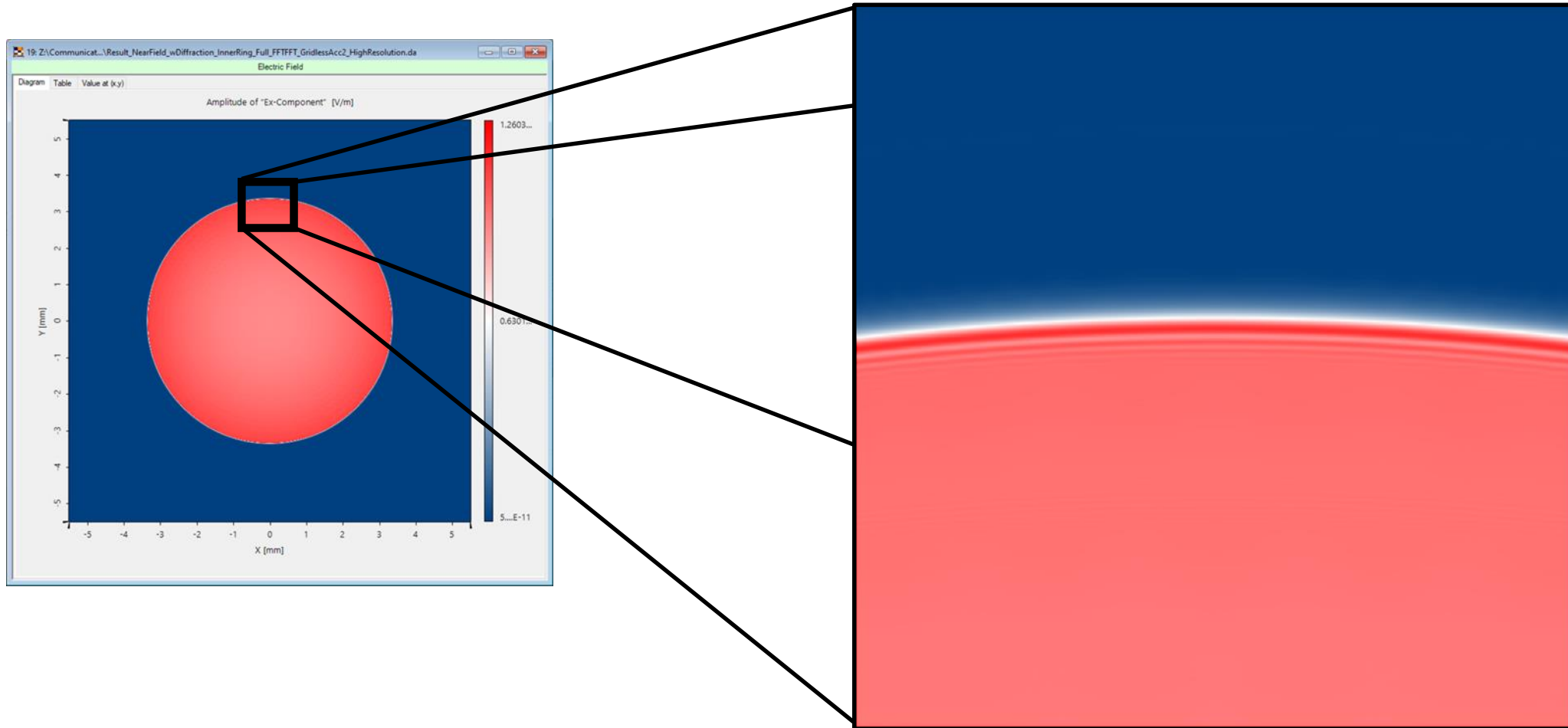
Focusing (NA = 0.4) Lens: Physical-Optics Modeling

Near Field Analysis – 500 μ m after Segmented Lens:



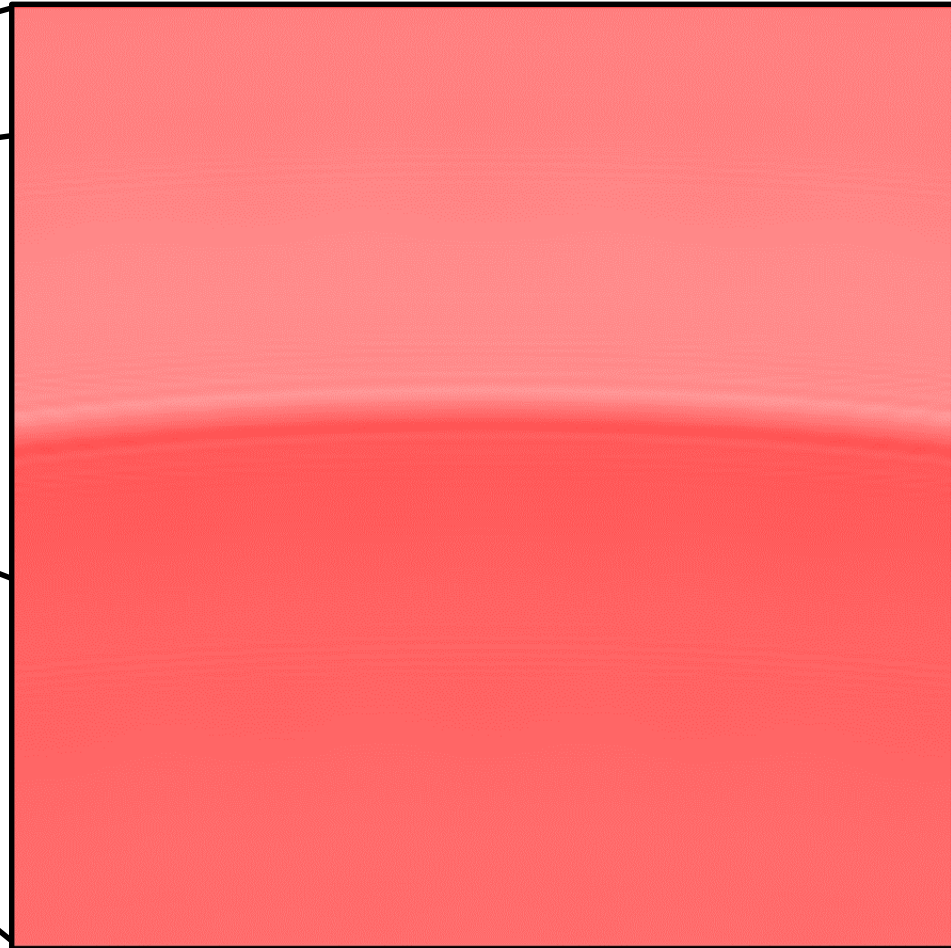
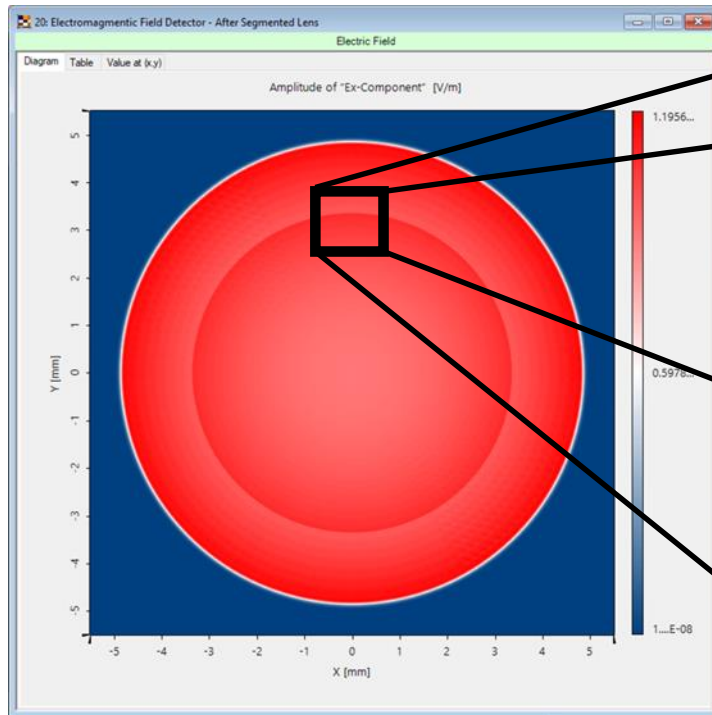
Focusing (NA = 0.4) Lens: Physical-Optics Modeling

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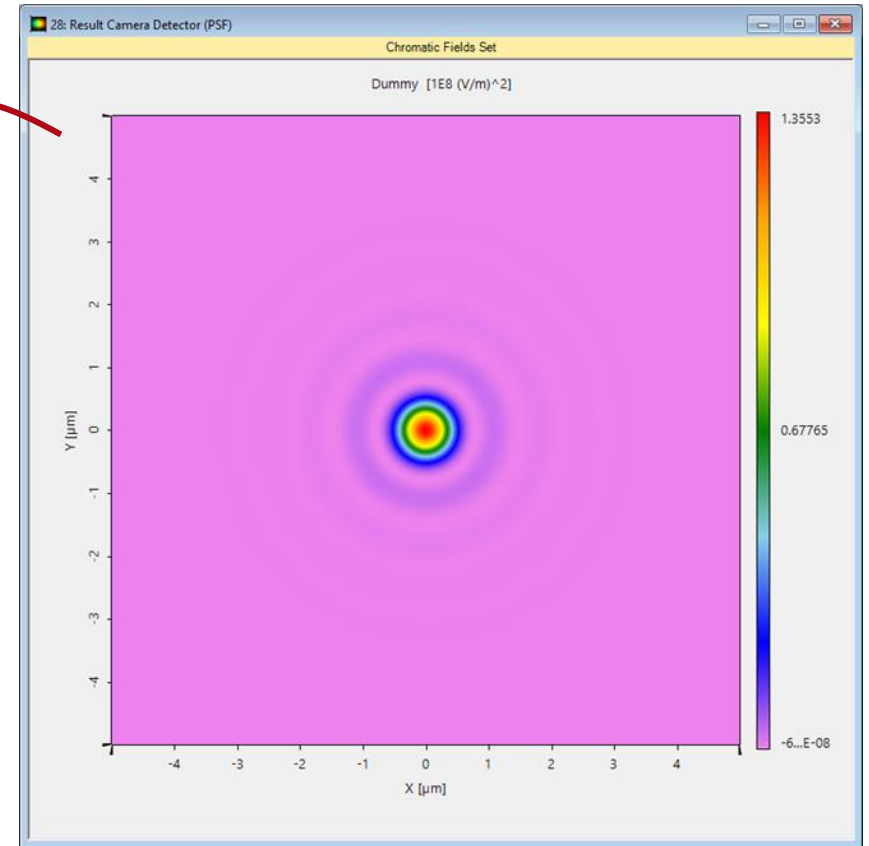
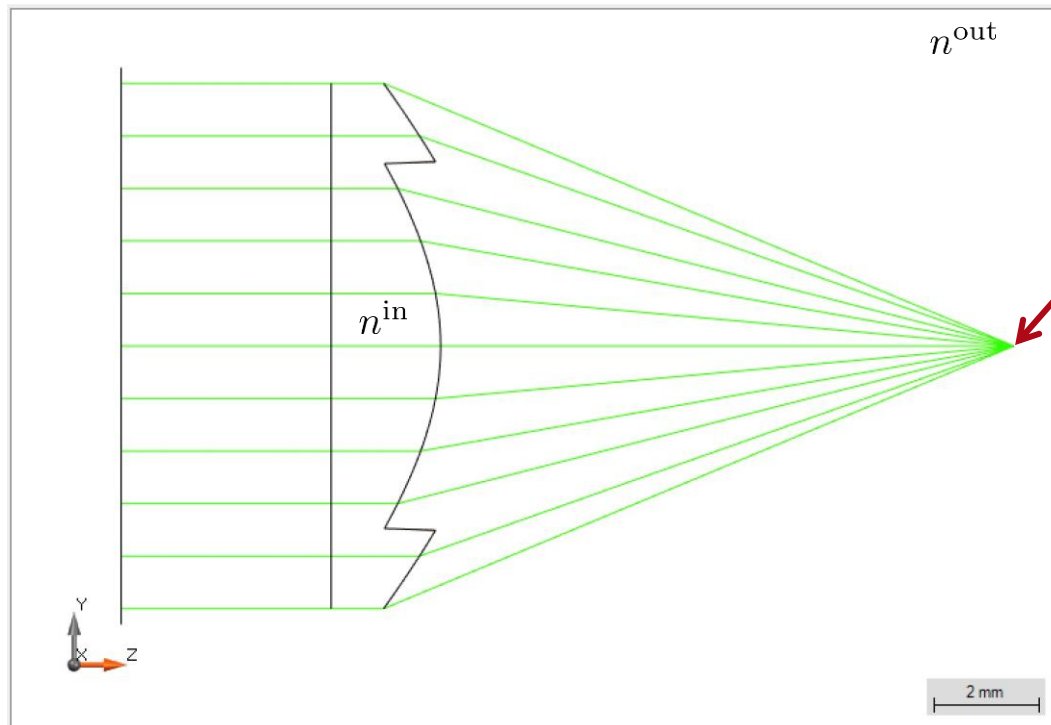


Focusing (NA = 0.4) Lens: Physical-Optics Modeling

Near Field Analysis – 500 μm after Segmented Lens:

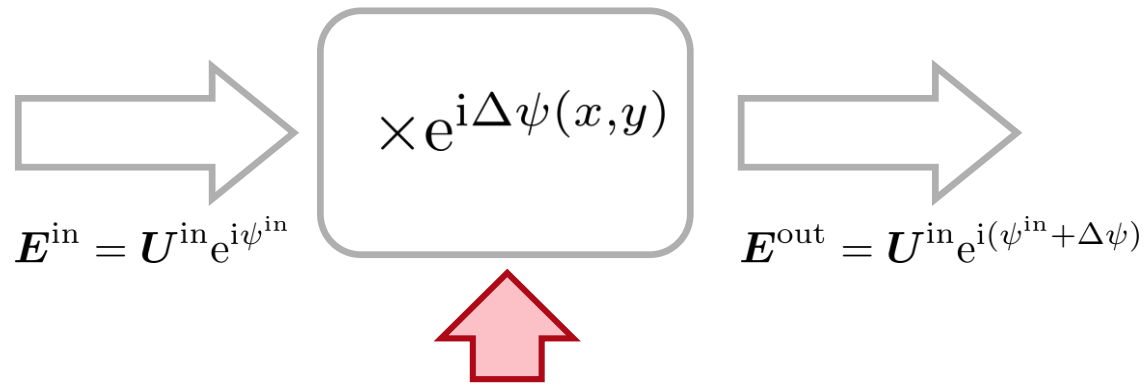


Focusing (NA = 0.4) Lens: Physical-Optics Modeling



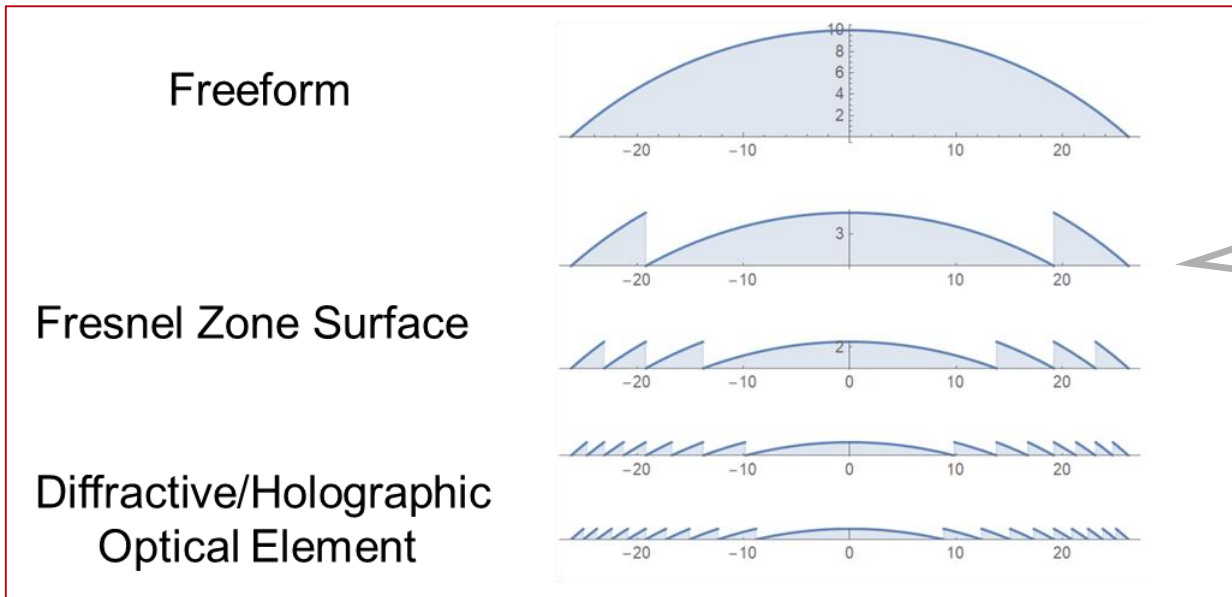
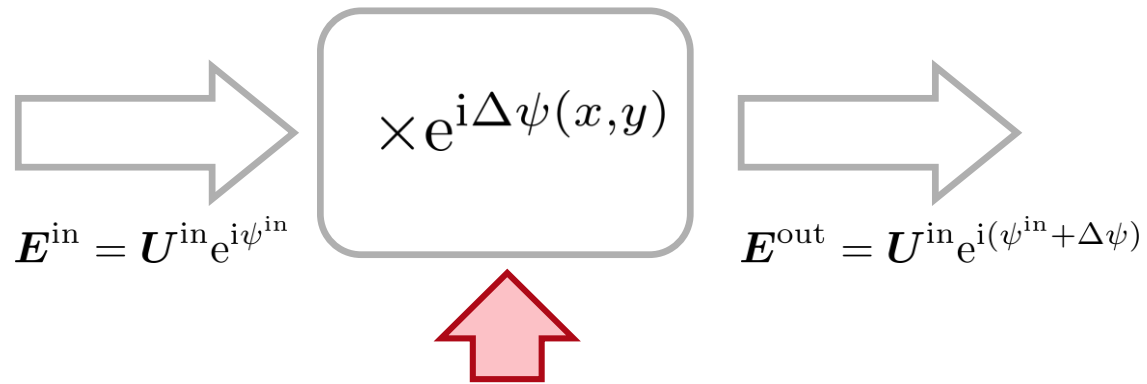
Intensity in focus

Wavefront Phase Manipulation



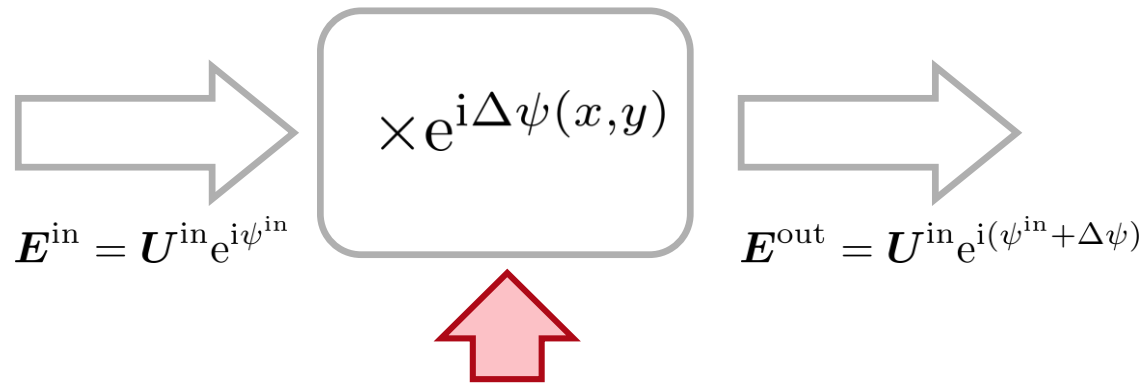
Which structures can be used
to realize wavefront phase
response in practice?

Wavefront Phase Manipulation



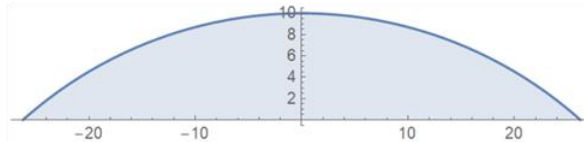
All surfaces control phase via optical path and height profile.

Wavefront Phase Manipulation



Use of effects at subwavelength structures for phase control.

Freeform



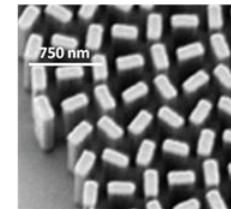
Fresnel Zone Surface



Diffractive/Holographic Optical Element



Metasurfaces



M. Khorasaninejad *et al.*, *Science* **352**, 1190-1194 (2016)

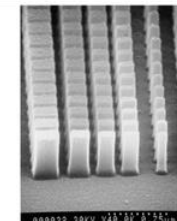
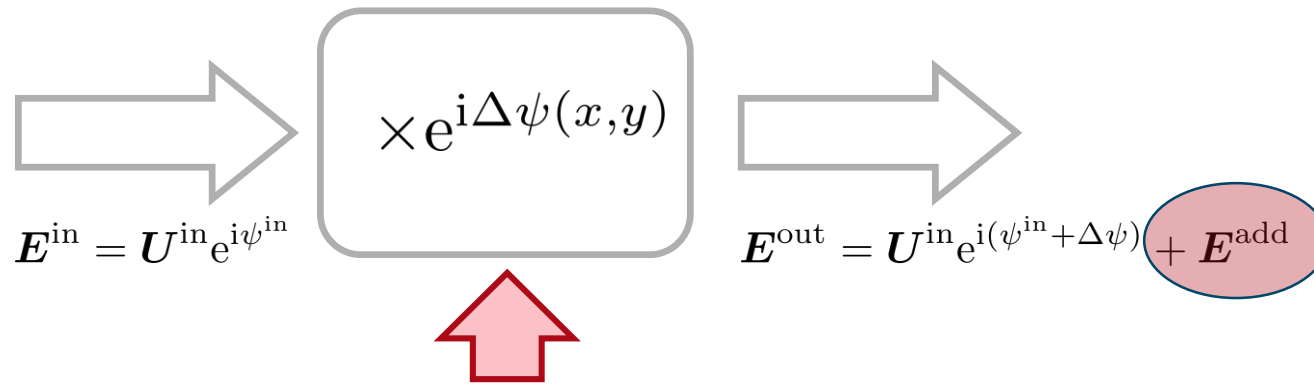


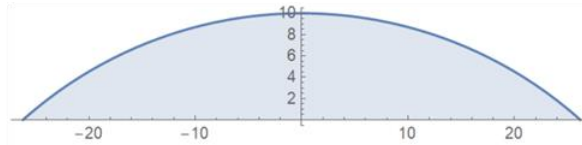
Fig. 2. Scanning-electron micrograph of the blazed binary subwavelength grating. The horizontal period (along the x axis) is 1.9 μm , and the period in the perpendicular direction (y axis) is equal to the sampling period (200 nm). The maximum pillar aspect ratio is 4.6.

P. Lalanne, *et al.*, "Blazed binary subwavelength gratings with efficiencies larger than those of conventional *échelette* gratings," *Opt. Lett.* **23**, 1081-1083 (1998)

Wavefront Phase Manipulation



Freeform



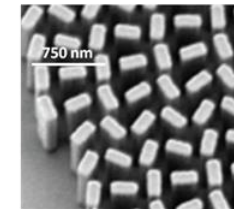
Fresnel Zone Surface



Diffractive/Holographic
Optical Element



Metasurfaces



M. Khorasaninejad *et al.*,
Science **352**, 1190-1194 (2016)

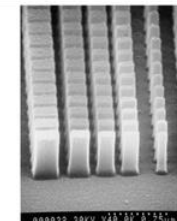


Fig. 2. Scanning-electron micrograph of the blazed binary subwavelength grating. The horizontal period (along the x axis) is 1.9 μm , and the period in the perpendicular direction (y axis) is equal to the sampling period (300 nm). The maximum pillar aspect ratio is 4.6.

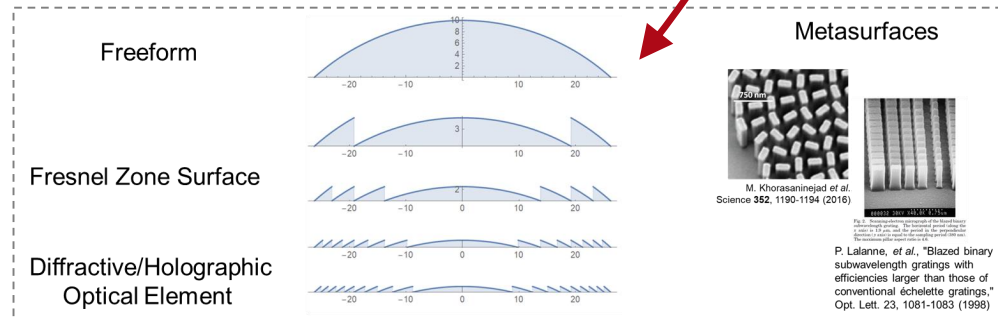
P. Lalanne, *et al.*, "Blazed binary subwavelength gratings with efficiencies larger than those of conventional *échelette* gratings," *Opt. Lett.* **23**, 1081-1083 (1998)

Fast Physical Optics Modeling and Design: Flat Optics

Physical optics modeling solvers can be seamlessly adapted to application scenario and design task.

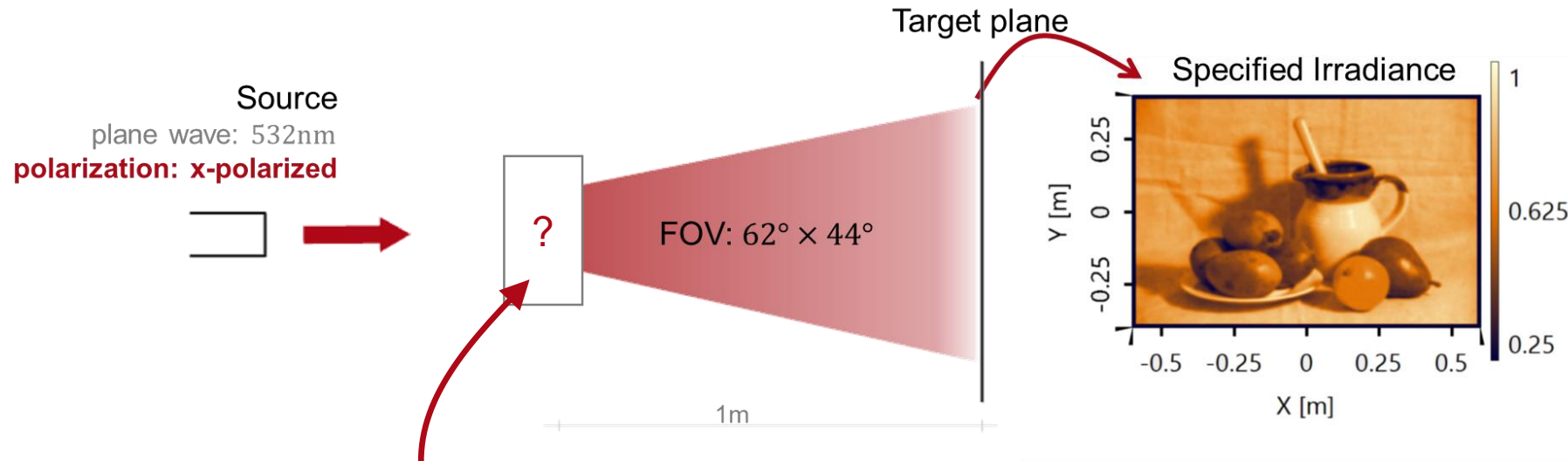
Fast Physical Optics

As fast as possible for given scenario and accuracy requirements



Application scenarios & modeling/design tasks

Scenario: Plane Wave to General Irradiance in Far Field



Functional design: Initial wavefront phase response

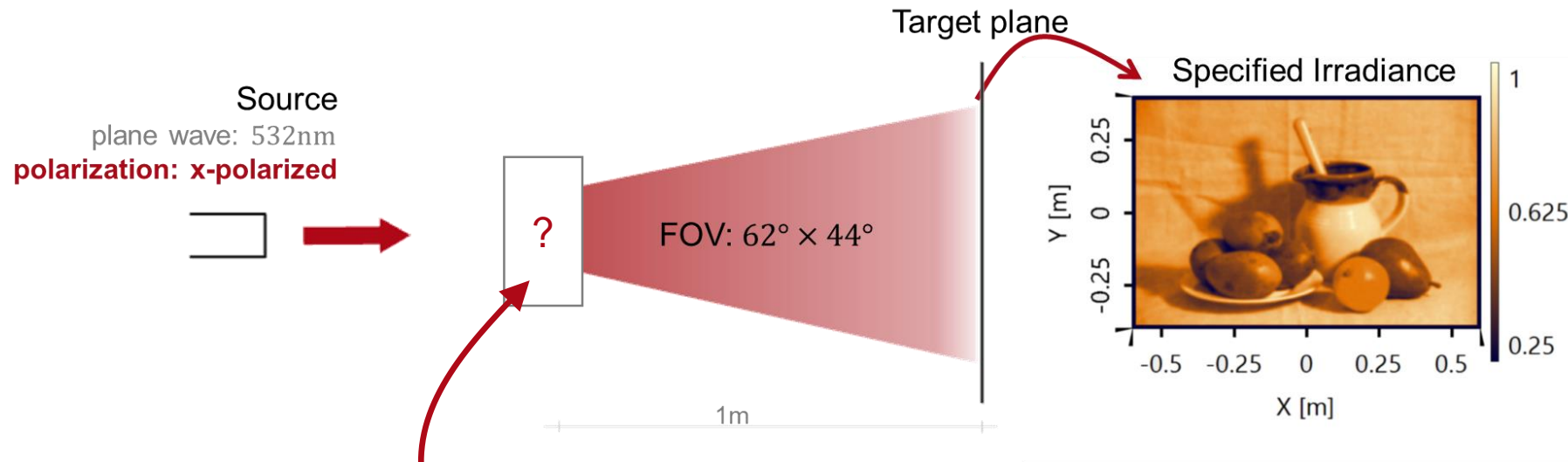
$E^{\text{in}} = U^{\text{in}} e^{i\psi^{\text{in}}}$

$\times e^{i\Delta\psi(x,y)}$

$E^{\text{out}} = U^{\text{in}} e^{i\psi^{\text{out}}} = U^{\text{in}} e^{i(\psi^{\text{in}} + \Delta\psi)}$

The diagram shows the functional design of the initial wavefront phase response. An input electric field vector $E^{\text{in}} = U^{\text{in}} e^{i\psi^{\text{in}}}$ is incident on a device. The device applies a phase response $\times e^{i\Delta\psi(x,y)}$ to the wavefront. The resulting output electric field vector is $E^{\text{out}} = U^{\text{in}} e^{i\psi^{\text{out}}} = U^{\text{in}} e^{i(\psi^{\text{in}} + \Delta\psi)}$.

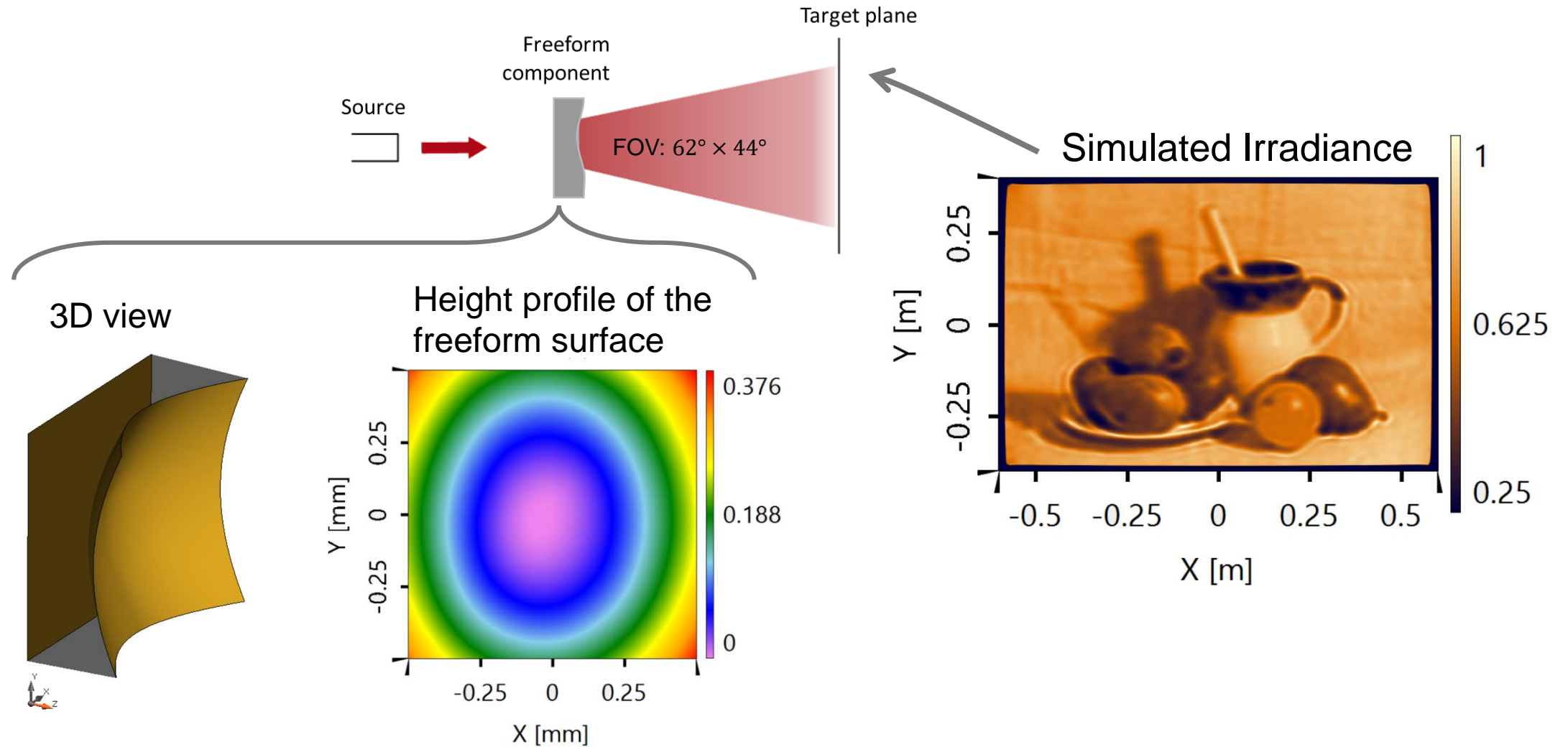
Scenario: Plane Wave to General Irradiance in Far Field



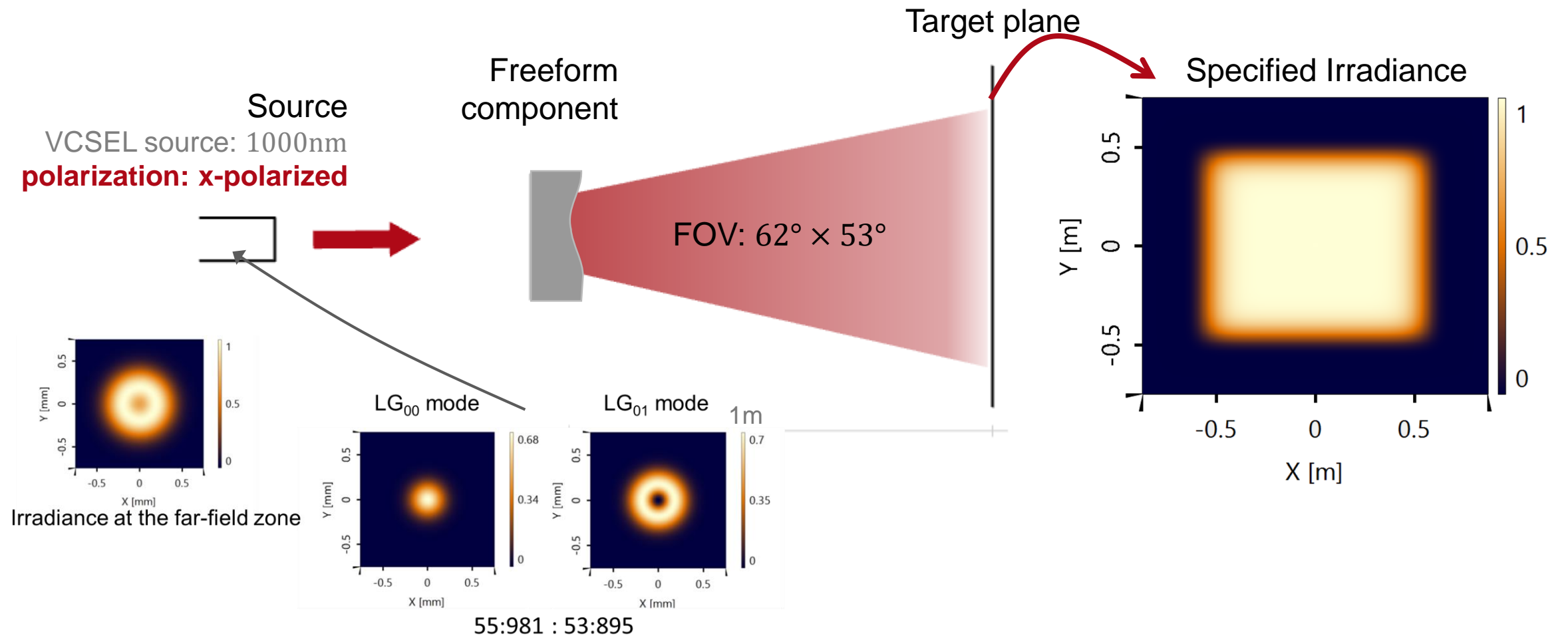
Structural design, e.g., smooth freeform surface

$$E^{\text{in}} = U^{\text{in}} e^{i\psi^{\text{in}}} \times e^{i\Delta\psi(x,y)} \rightarrow E^{\text{out}} = U^{\text{in}} e^{i\psi^{\text{out}}} = U^{\text{in}} e^{i(\psi^{\text{in}} + \Delta\psi)}$$

Scenario: Plane Wave to General Irradiance in Far Field

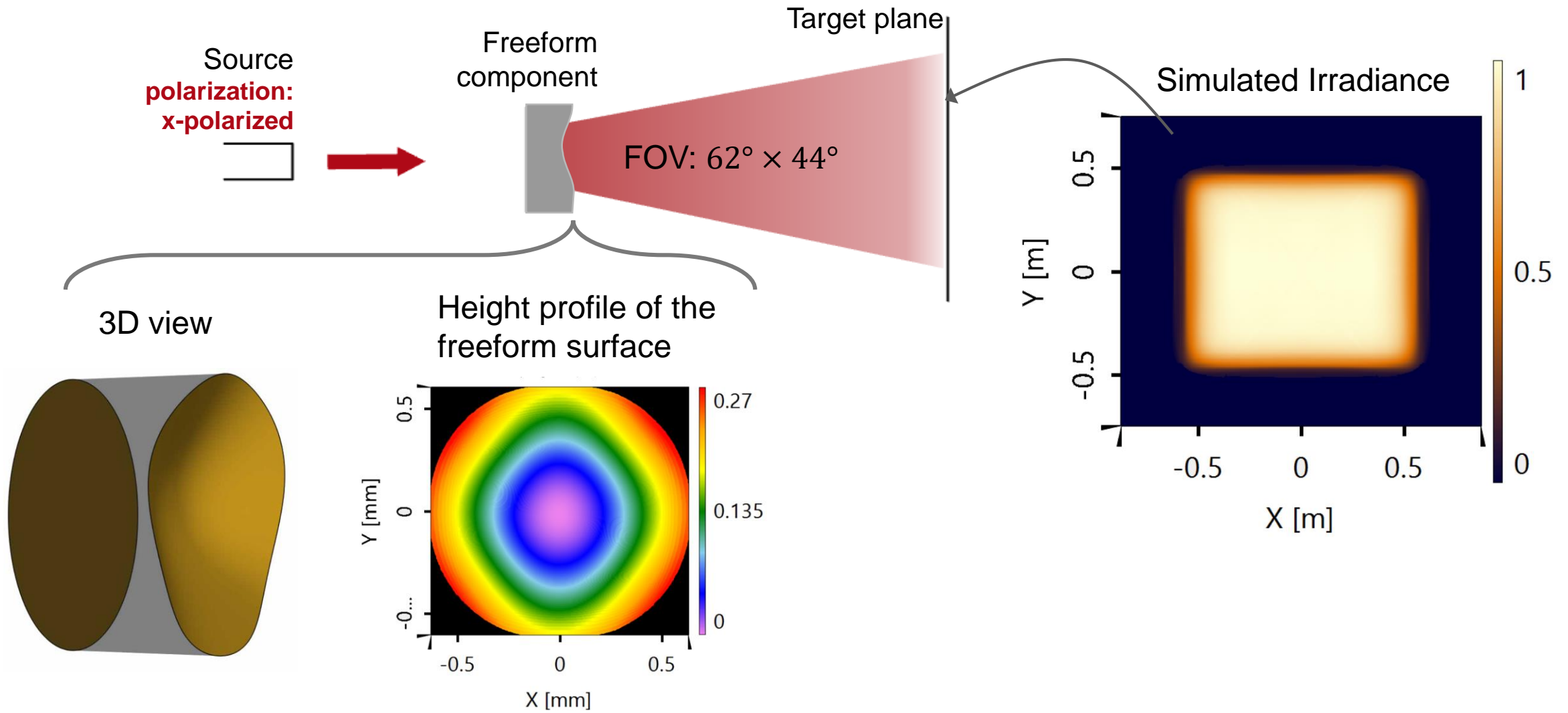


Scenario: Multimode Source to Top Hat in Far Field

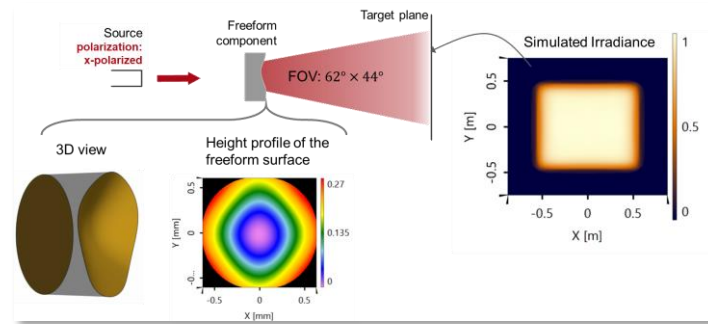


Source with two modes

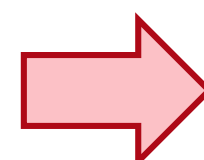
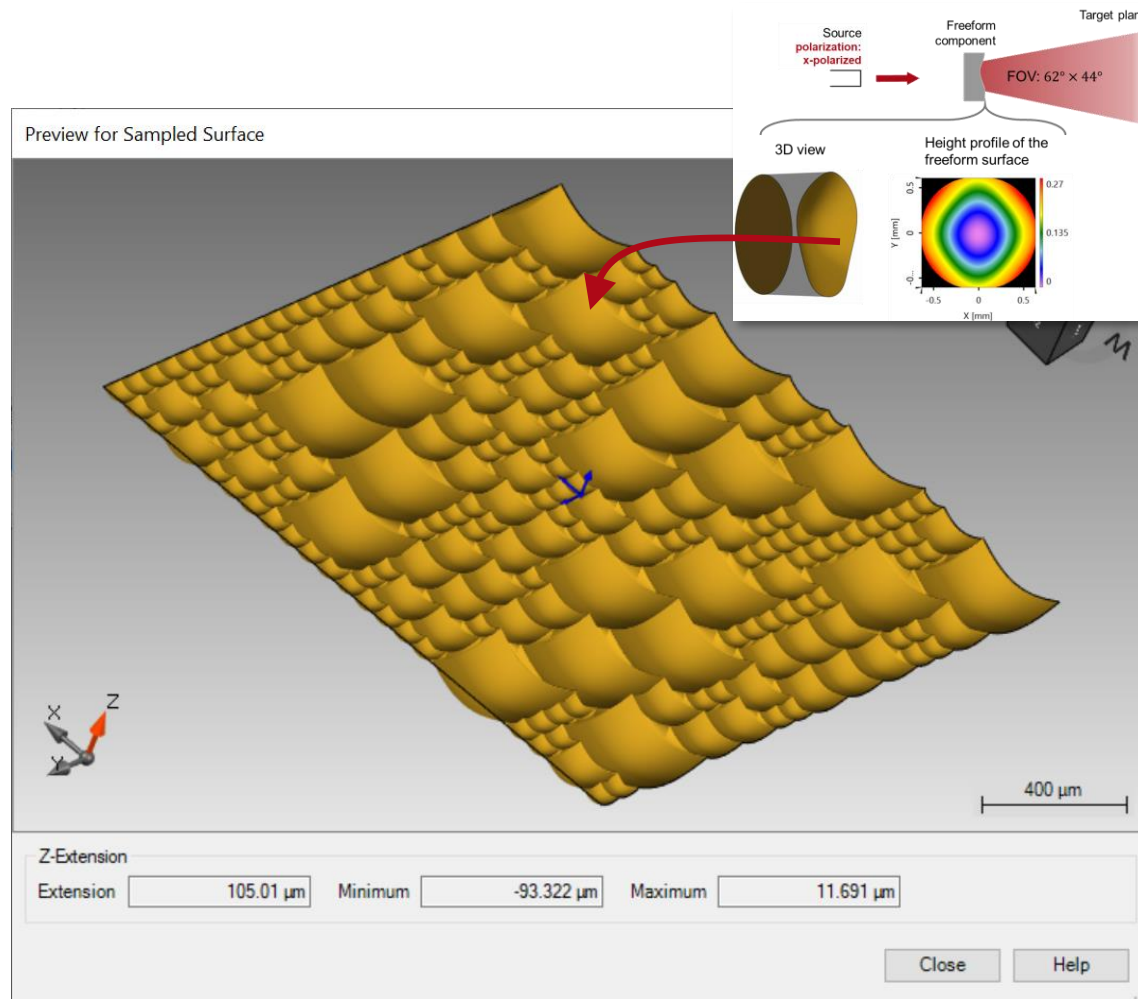
Scenario: Multimode Source to Top Hat in Far Field



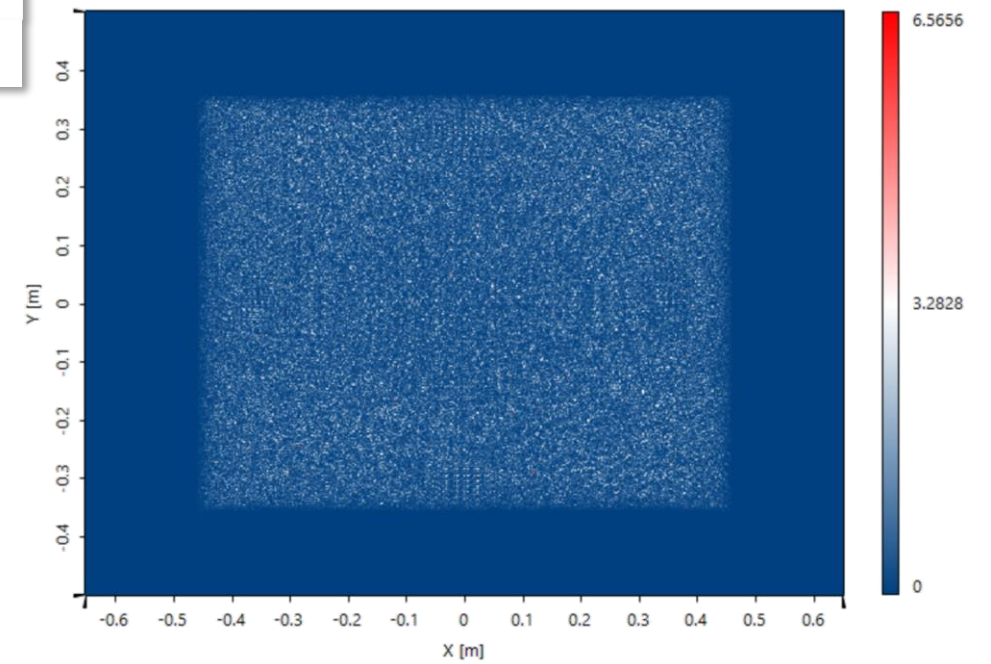
Diffuser Design and Modeling



Diffuser Design and Modeling



Far Field Irradiance

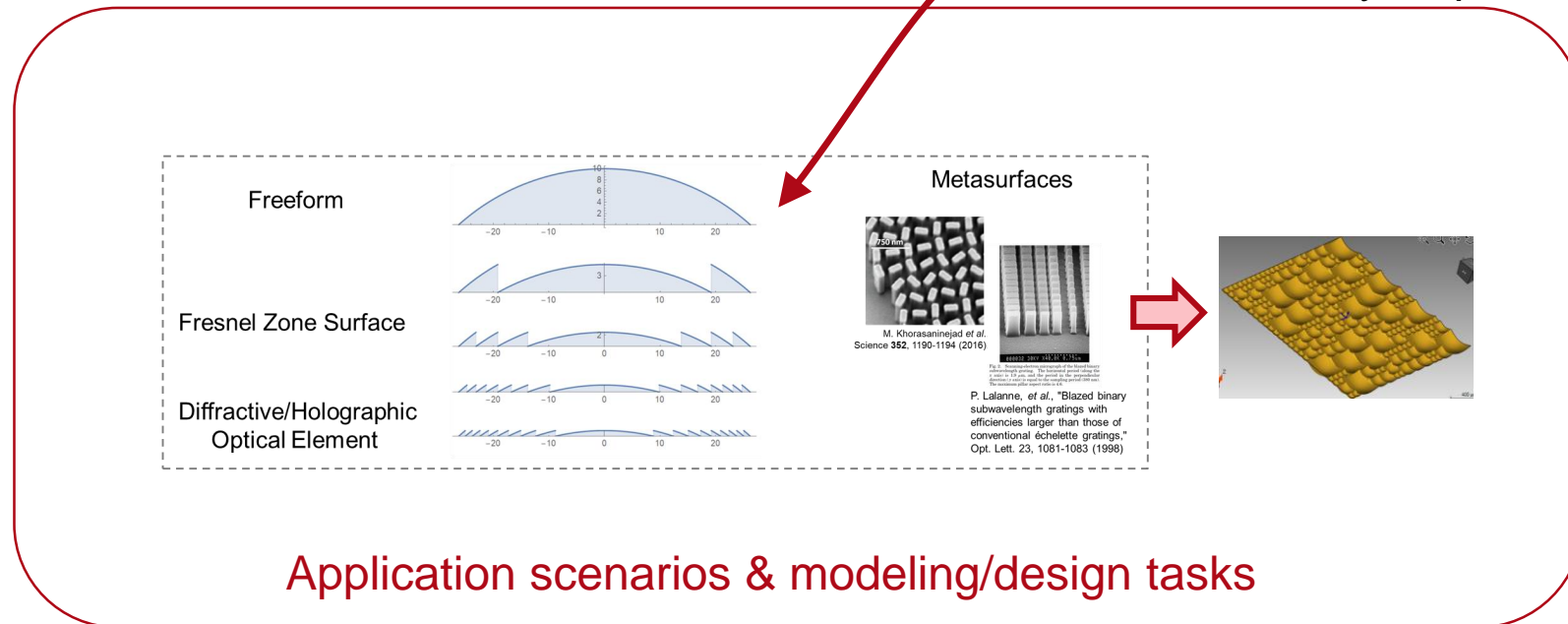


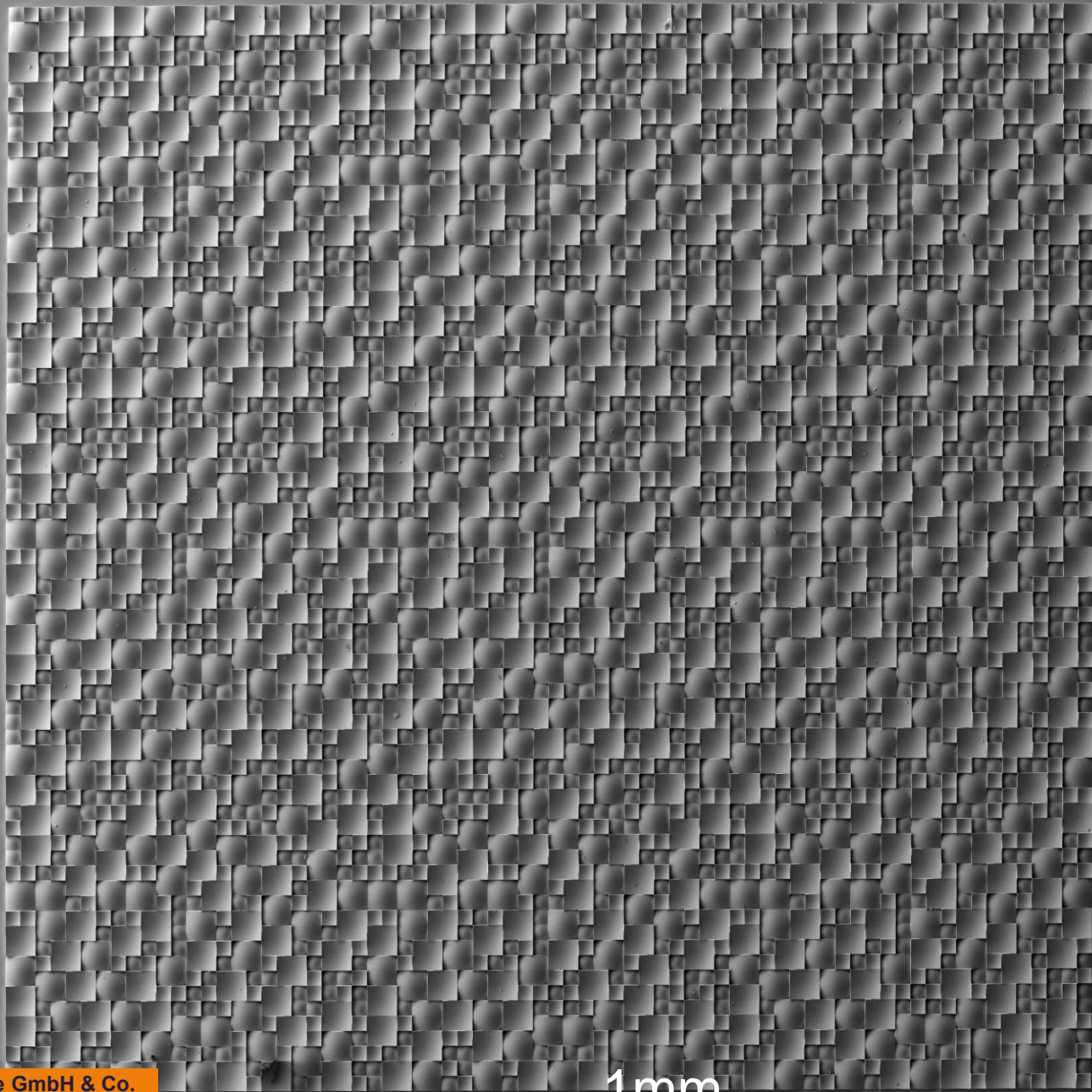
Fast Physical Optics Modeling and Design: Flat Optics

Physical optics modeling solvers can be seamlessly adapted to application scenario and design task.

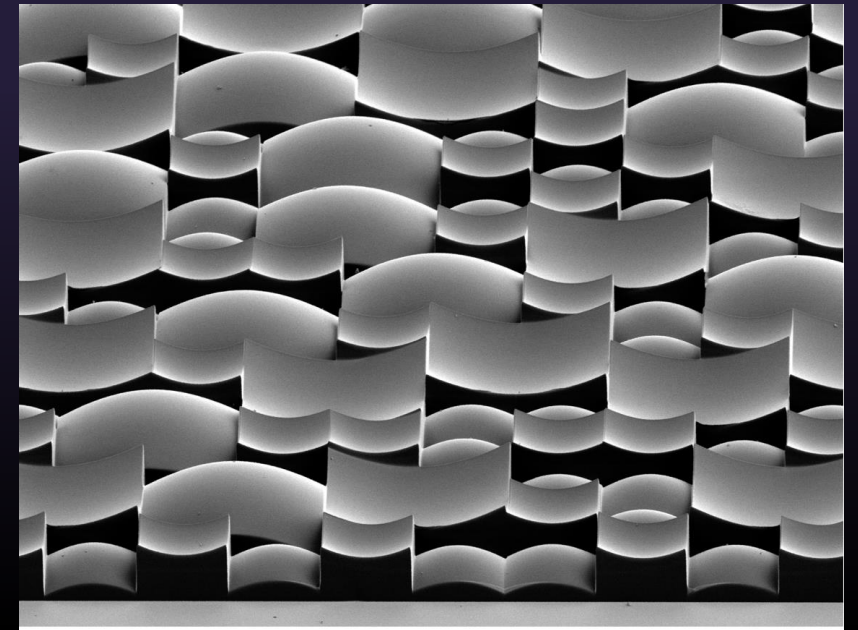
Fast Physical Optics

As fast as possible for given scenario and accuracy requirements





1 mm

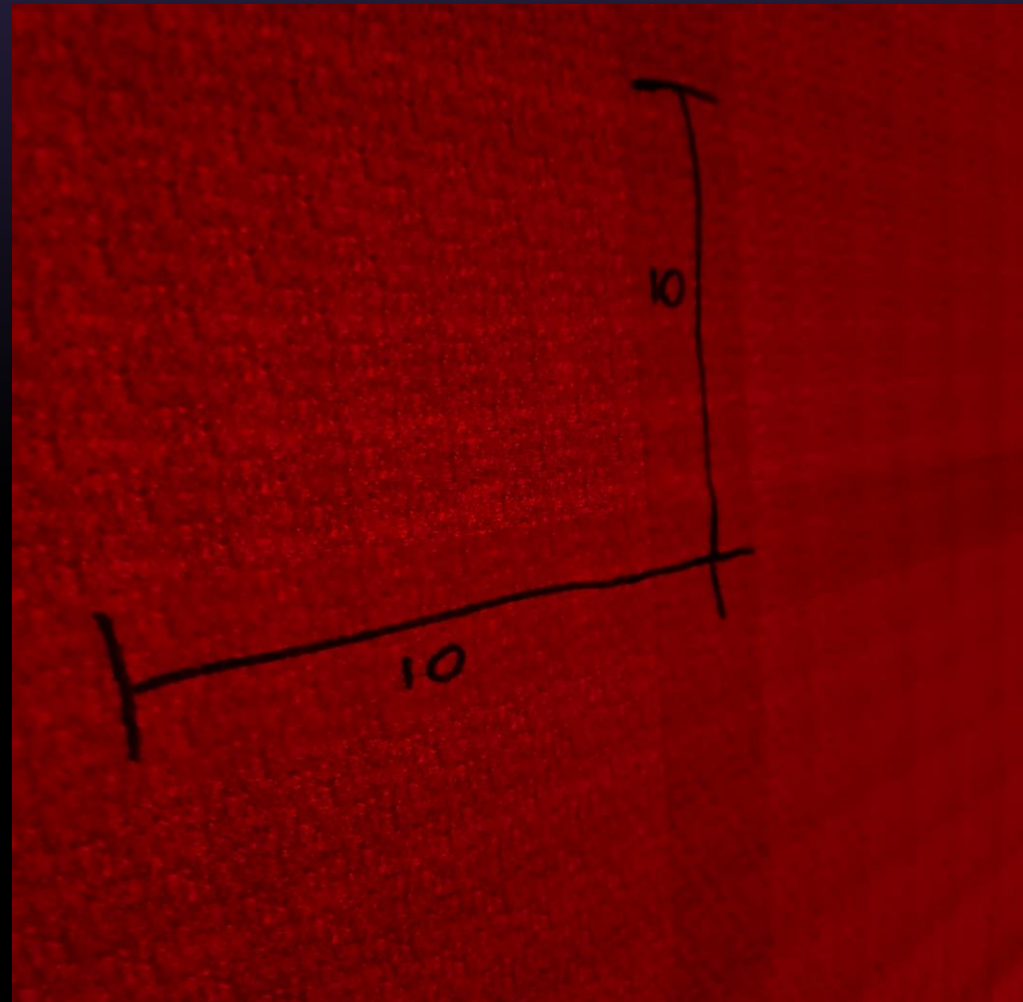


Very uniform patterning
accuracy over extensive
areas
5.4 mm by 5.4 mm

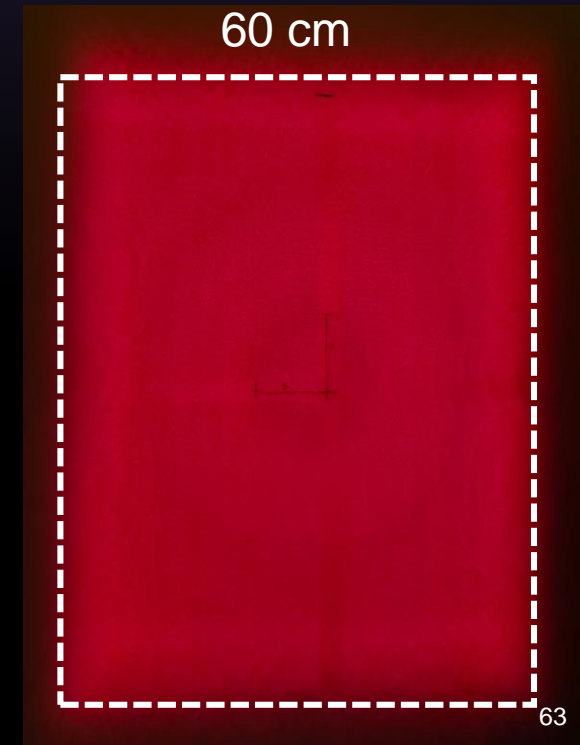
Diffuser based on randomized array of freeform light shaper



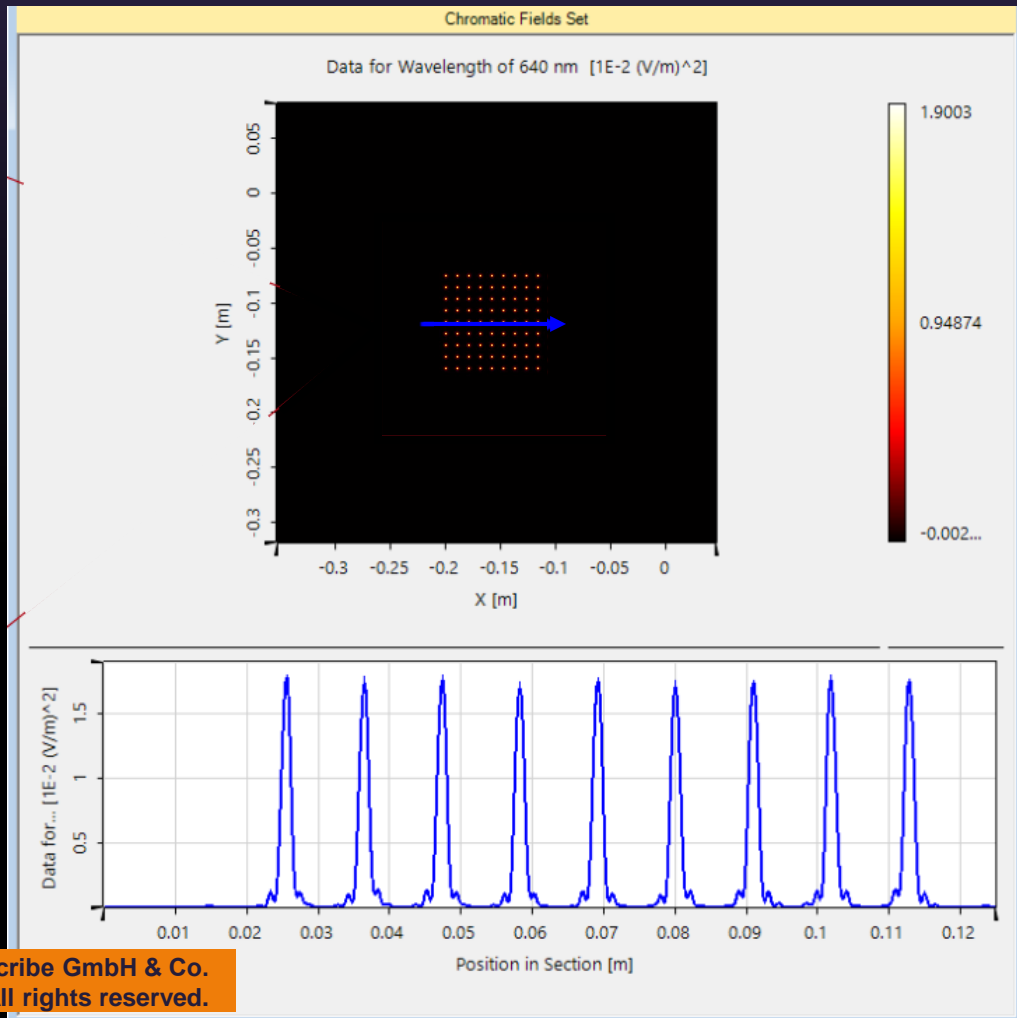
- Experimental results



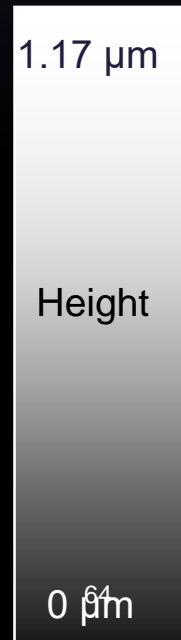
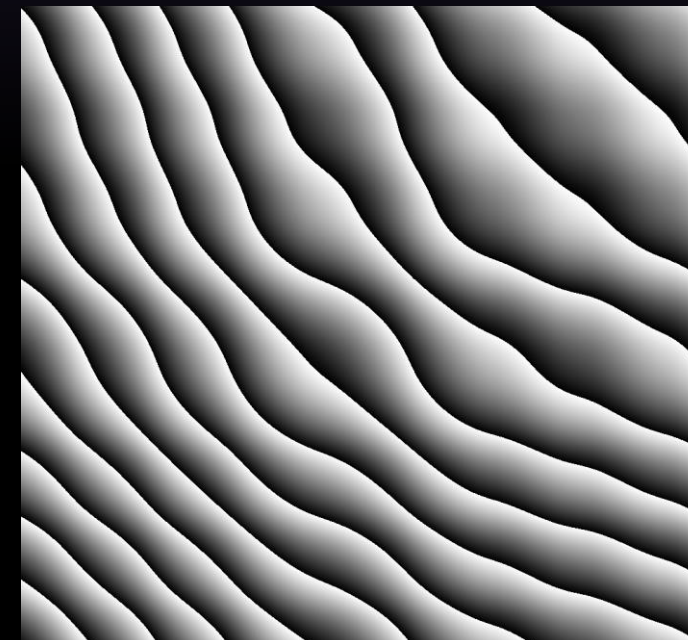
Mixed



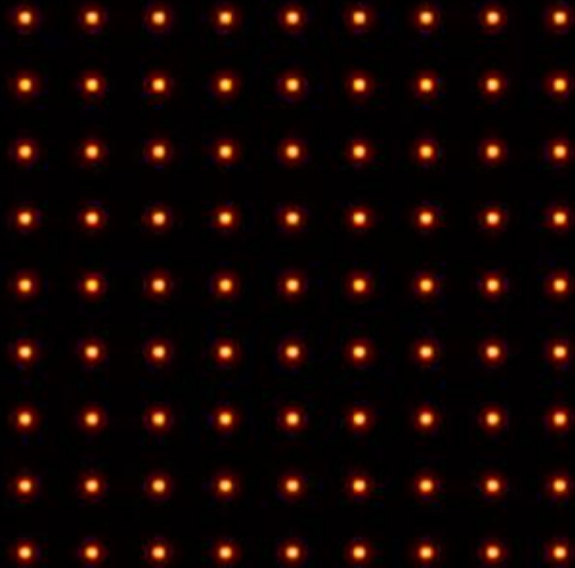
Grating for 9x9 dot grid projection (off-axis)



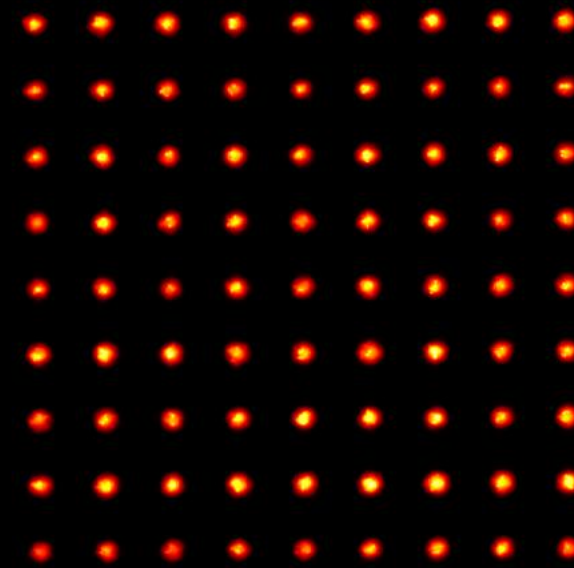
- ▶ Continuous height profile with 65535 levels
- ▶ Printing time independent from level number with 2GL



DOE for 9x9 dot grid projection



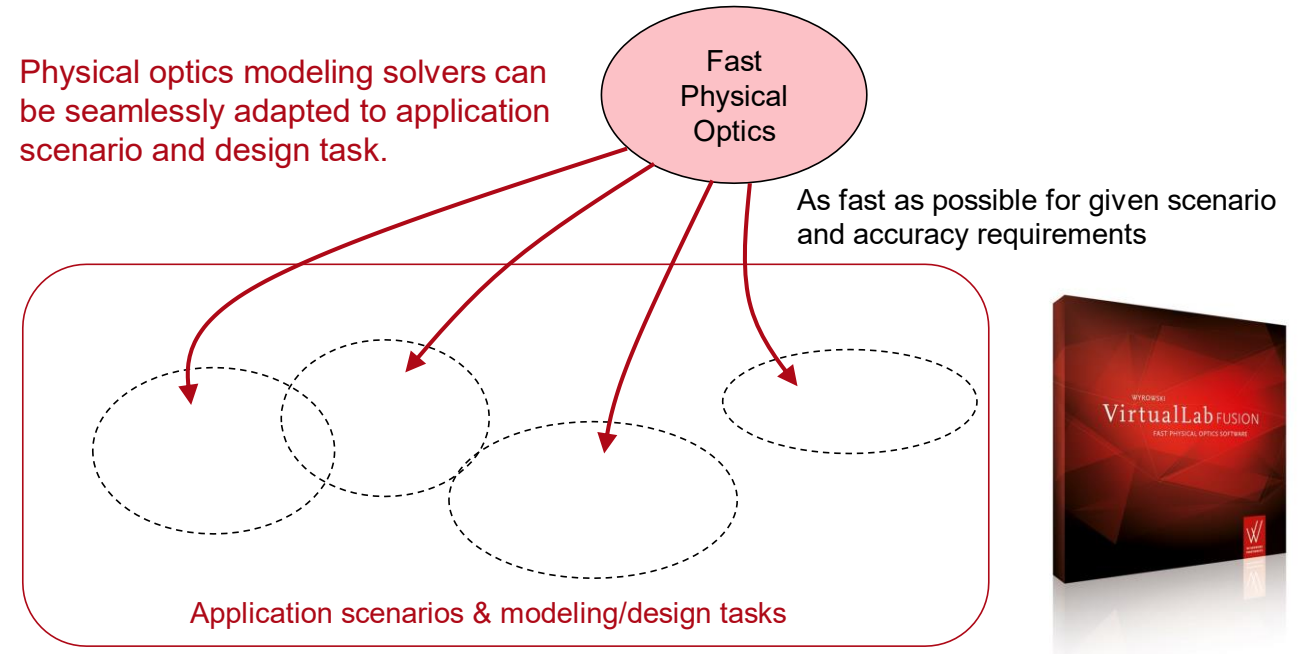
▶ Simulation (off-axis)



▶ optical experiment (off-axis)

Summary

- Fast physical optics theory and software most flexible in modeling and design.
- Flat optics examples:
 - Segmented smooth surfaces
 - Subwavelength structures (meta surfaces)
 - Regular and randomized arrays
- Nanoscribe greyscale technology very promising for fabrication of flat optics.



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